



# **Total Ionizing Dose Test Report**

**No. 13T-RTSX72SU-CQ256-D1WWA1**

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September 26, 2013

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## TOTAL IONIZING DOSE TEST REPORT

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September 26, 2013

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### I. Summary Table

| Parameter                           | Tolerance                                                         |
|-------------------------------------|-------------------------------------------------------------------|
| 1. Gross Functionality              | Passed 100 krad (SiO <sub>2</sub> )                               |
| 2. Power Supply Current (ICCA/ICCI) | Passed 40 krad (SiO <sub>2</sub> )                                |
| 3. Input Threshold (VTIL/VIH)       | Passed 100 krad (SiO <sub>2</sub> )                               |
| 4. Output Drive (VOL/VOH)           | Passed 100 krad (SiO <sub>2</sub> )                               |
| 5. Propagation Delay                | Passed 100 krad (SiO <sub>2</sub> ) for 10% degradation criterion |
| 6. Transition Characteristics       | Passed 100 krad (SiO <sub>2</sub> )                               |

### II. Total Ionizing Dose (TID) Testing

This testing is designed on the base of an extensive database (see TID data of antifuse-based FPGAs at <http://www.klabs.org> and <http://www.microsemi.com/soc>) accumulated from the TID testing of many generations of antifuse-based FPGAs.

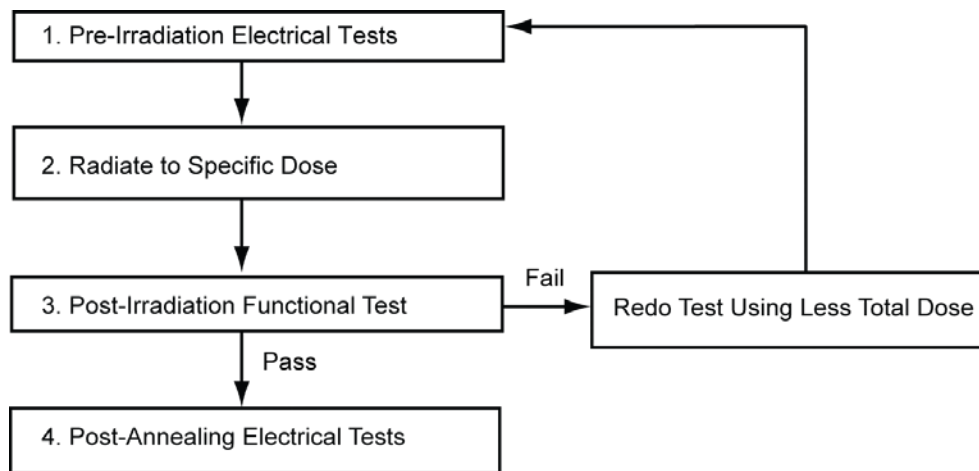
#### A. Device-Under-Test (DUT) and Irradiation Parameters

Table 1 lists the DUT and irradiation parameters. During irradiation each input or output is grounded through a resistor; during annealing each input or output is grounded through a 1-k ohm resistor. Appendix A contains the schematics of the bias circuit.

Table 1 DUT and Irradiation Parameters

|                                              |                                                                                                                             |
|----------------------------------------------|-----------------------------------------------------------------------------------------------------------------------------|
| Part Number                                  | RTSX72SU                                                                                                                    |
| Package                                      | CQFP256                                                                                                                     |
| Foundry                                      | United Microelectronics Corp.                                                                                               |
| Technology                                   | 0.25 $\mu$ m CMOS                                                                                                           |
| DUT Design                                   | TDSX72CQFP256_2Strings_r1                                                                                                   |
| Die Lot Number                               | D1WWA1                                                                                                                      |
| Quantity Tested                              | 6                                                                                                                           |
| Serial Number                                | 100 krad(SiO <sub>2</sub> ): 7422, 7437<br>60 krad(SiO <sub>2</sub> ): 7442, 7459<br>40 krad(SiO <sub>2</sub> ): 7508, 7579 |
| Radiation Facility                           | Defense Microelectronics Activity                                                                                           |
| Radiation Source                             | Co-60                                                                                                                       |
| Dose Rate ( $\pm$ 5%)                        | 10 krad(SiO <sub>2</sub> )/min                                                                                              |
| Irradiation Temperature                      | Room                                                                                                                        |
| Irradiation and Measurement Bias (VCCI/VCCA) | Static at 5.0 V/2.5 V                                                                                                       |

## B. Test Method



**Figure 1 Parametric Test Flow Chart**

The test method generally follows the guidelines in the military standard TM1019.8. Figure 1 is the flow chart describing the steps for functional and parametric tests, irradiation, and post-irradiation annealing.

The accelerated aging, or rebound test mentioned in TM1019.8 is unnecessary because there is no adverse time-dependent effect (TDE) in Microsemi products manufactured by deep sub-micron CMOS technologies. Elevated temperature annealing basically reduces the effects originating from radiation-induced leakage currents. As indicated by test data in the following sections, the predominant radiation effects in RTSX72SU are due to radiation-induced leakage currents.

Room temperature annealing is performed in this test; the duration is approximately 7 days.

## C. Design and Parametric Measurements

DUTs use a high utilization generic design (TDSX72CQ256\_2Strings\_r1) to test total dose effects in typical space applications. Appendix B contains the schematics illustrating the logic design.

Table 2 lists each electrical parameter and the corresponding logic design. The functionality is measured on the output pins (O\_AND3 and O\_AND4) of two combinational buffer-strings with 1400 buffers each and output pins (O\_OR4 and O\_NAND4) of a shift register with 1536 bits. ICC is measured on the power supply of the logic-array (ICCA) and I/O (ICCI) respectively. The input logic thresholds (VTIL/VIH) and output-drive voltages (VOL/VOH) are measured on combinational nets listed in Row 3 and 4 in Table 2. The propagation delays are measured on the O\_AND4 output of one buffer string. The delay is defined as the time delay from the time of triggering edge at the CLOCK input to the time of switching state at the output O\_AND4. Both the low-to-high and high-to-low output transitions are measured; the propagation delay is defined as the average of these two transitions. The transition characteristics, measured on the output O\_AND4, are displayed as oscilloscope snapshots showing the rising and falling edge during logic transitions.

**Table 2 Logic Design for Parametric Measurements**

| Parameters                   | Logic Design                                                                                                                                           |
|------------------------------|--------------------------------------------------------------------------------------------------------------------------------------------------------|
| 1. Functionality             | All key architectural functions (pins O_AND3, O_AND4, O_OR3, O_OR4, and O_NAND4)                                                                       |
| 2. ICC (ICCA/ICCI)           | DUT power supply                                                                                                                                       |
| 3. Input Threshold (VIL/VIH) | Input buffers (DA/QA0, DAH/QA0H, ENCNTRH/YO0H, IDI10/IDIO0, IDI11/IDIO1, IDI12/IDIO2, IDI13/IDIO3, IDI14/IDIO4, IDI15/IDIO5, IDI16/IDIO6, IDI17/IDIO7) |
| 4. Output Drive (VOL/VOH)    | Output buffer (DA/QA0)                                                                                                                                 |
| 5. Propagation Delay         | String of buffers (pin LOADIN to O_AND4)                                                                                                               |
| 6. Transition Characteristic | D flip-flop output (O_AND4)                                                                                                                            |

### III. Test Results

#### A. Functionality

Every DUT passes the pre-irradiation, post-irradiation, and post-annealing functional tests.

#### B. Power Supply Current (ICCA and ICCI)

Table 3 summarizes the pre-irradiation, post-irradiation—right after irradiation and before anneal, and post-annealing ICCA and ICCI data.

**Table 3 Pre-irradiation, Post Irradiation and Post-Annealing ICC**

| DUT  | Total Dose | ICCA (mA) |            |          | ICCI (mA) |            |          |
|------|------------|-----------|------------|----------|-----------|------------|----------|
|      |            | Pre-irrad | Post-irrad | Post-ann | Pre-irrad | Post-irrad | Post-ann |
| 7422 | 100 krad   | 1.33      | 266        | 172      | 1.01      | 218        | 151      |
| 7437 | 100 krad   | 2.21      | 346        | 243      | 1.04      | 243        | 166      |
| 7442 | 60 krad    | 1.10      | 78         | 21       | 0.75      | 22         | 38       |
| 7459 | 60 krad    | 1.06      | 23         | 19       | 1.04      | 24         | 34       |
| 7508 | 40 krad    | 1.07      | 4          | 4        | 1.01      | 4          | 4        |
| 7579 | 40 krad    | 1.06      | 4          | 4        | 1.05      | 4          | 4        |

In compliance with TM1019.8, the post-irradiation-parametric limit (PIPL) for the post-annealing ICCA/ICCI in this test, is defined as the highest ICCA/ICCI in the RTSXSU spec sheet of 25 mA.

Figure 2 through Figure 7 plot the influx standby ICCA and ICCI versus total dose for each DUT.

There are unexpected ICCI increases during irradiation, as shown in Figures 3 through 7, where the ICCI would drop back at some points of time. The suspect is an intermittent continuity problem of the socket on the test board. The post-anneal ICCI measurements are more stable.

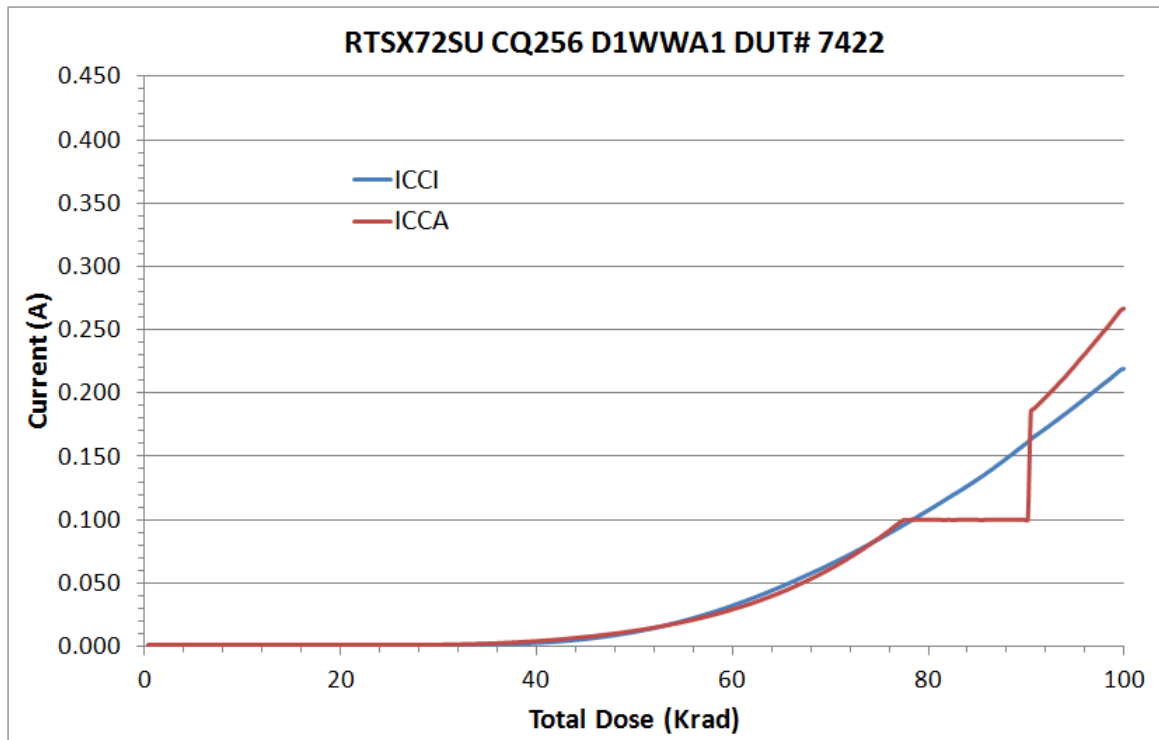


Figure 2 DUT 7422 Influx ICCA and ICCI

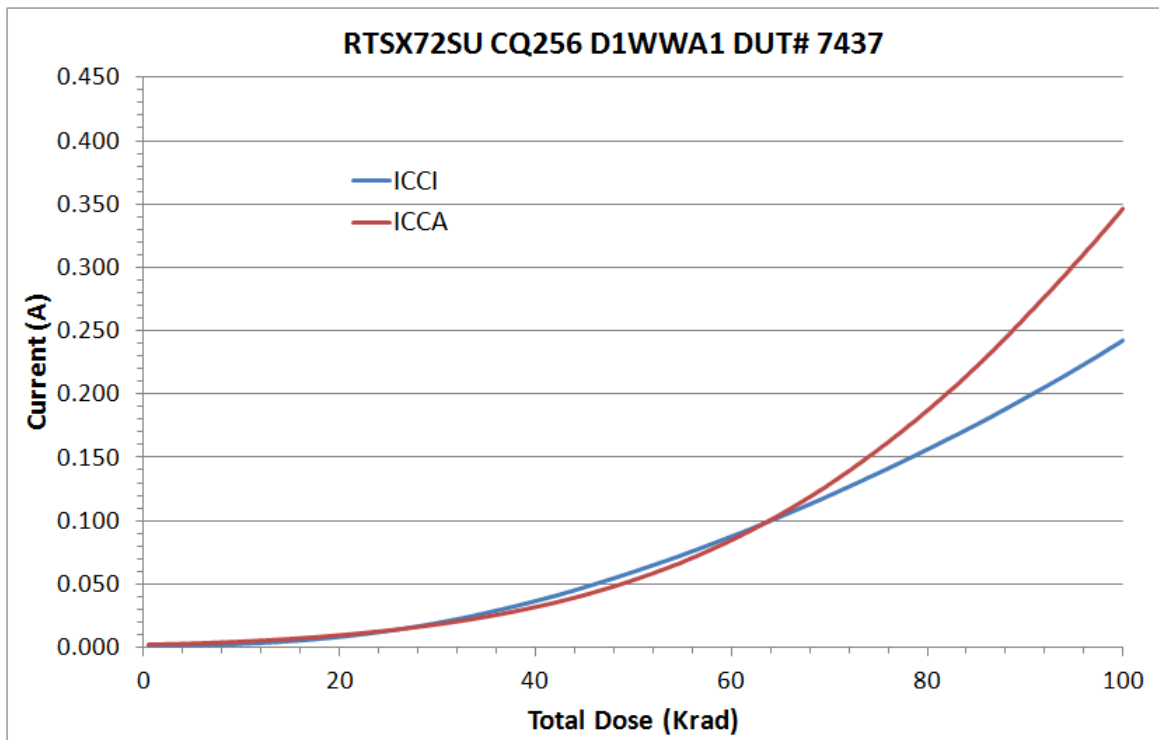


Figure 3 DUT 7437 Influx ICCA and ICCI

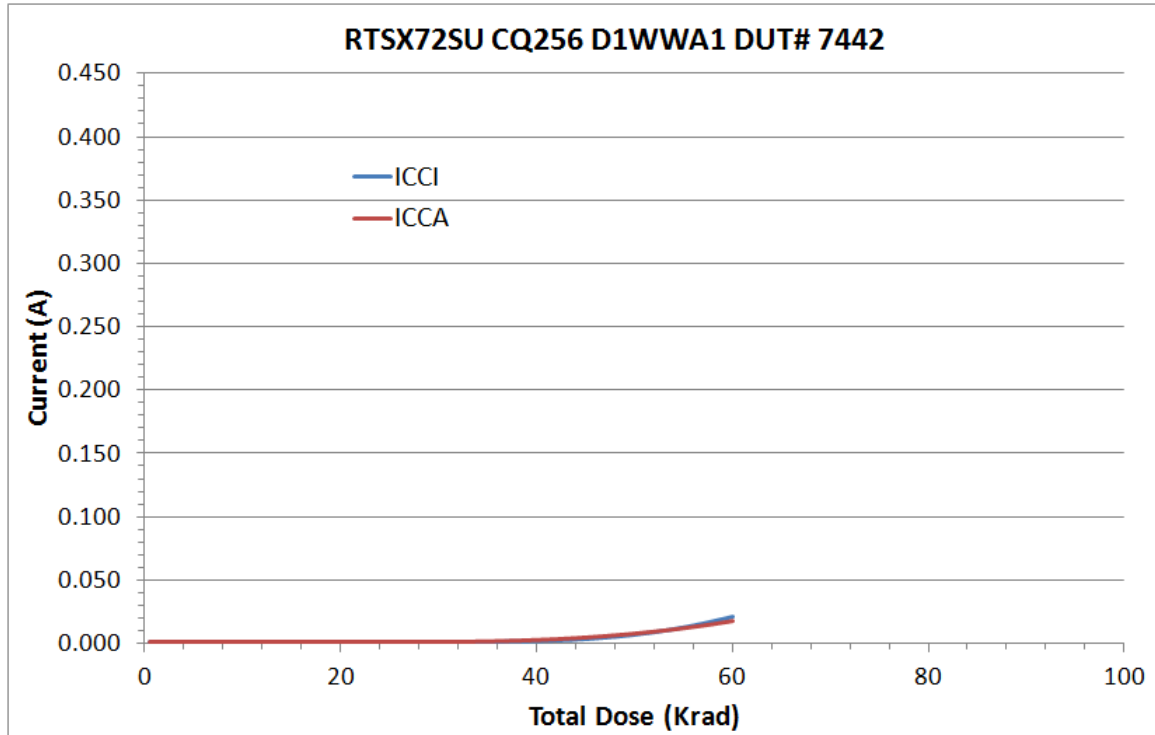


Figure 4 DUT 7442 Influx ICCA and ICCI

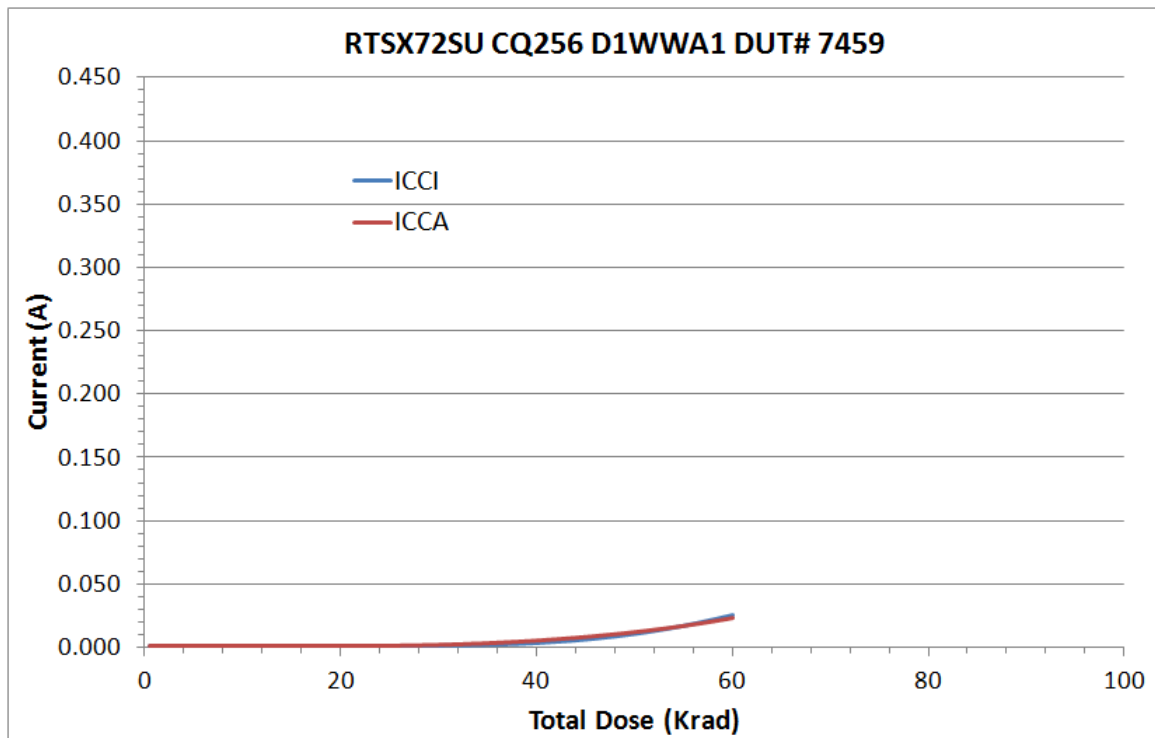


Figure 5 DUT 7459 Influx ICCA and ICCI

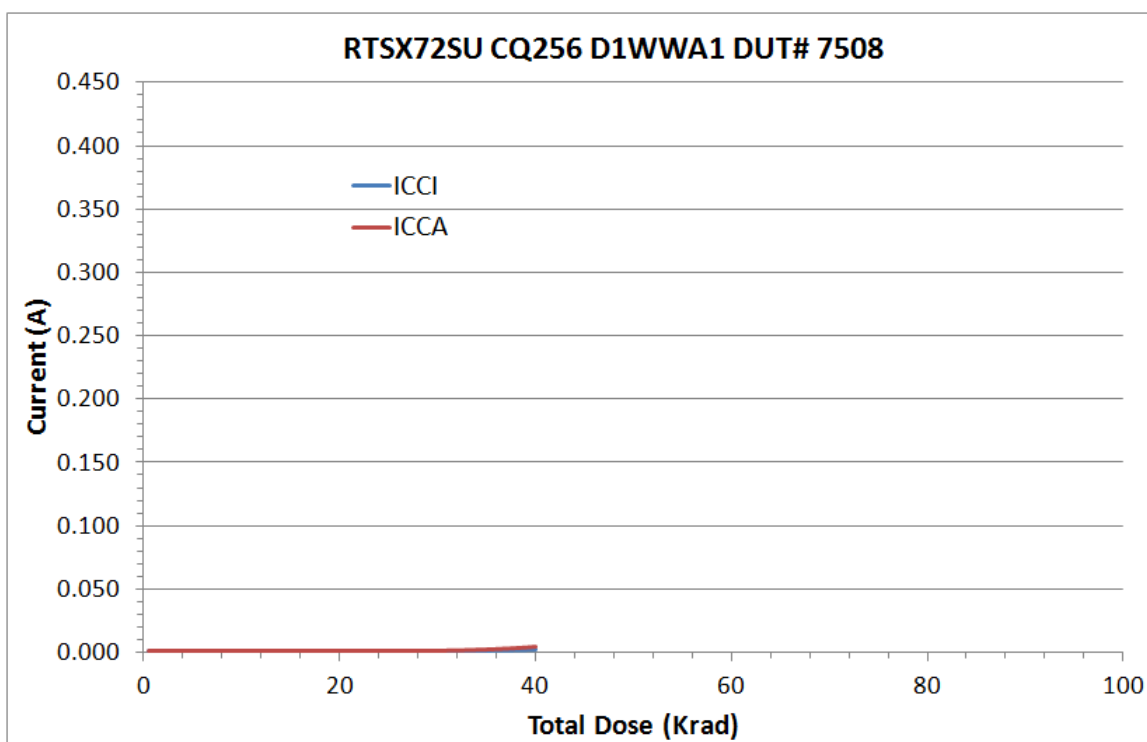


Figure 6 DUT 7508 Influx ICCA and ICCI

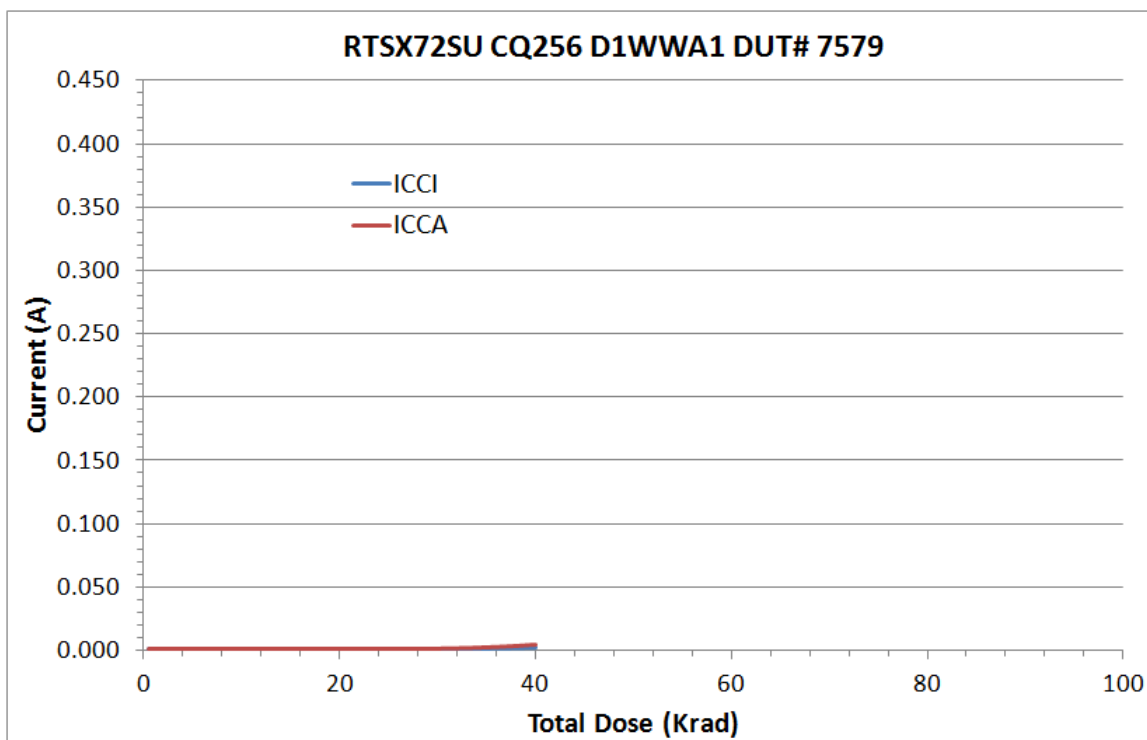


Figure 7 DUT 7579 Influx ICCA and ICCI

## C. Input Logic Threshold (VIL/VIH)

Table 4a through Table 4c list the pre-irradiation and post-annealing input logic thresholds. All data is within the specification limits. The post-annealing shift in every case is very small.

**Table 4a Pre-Irradiation and Post-Annealing Input Thresholds**

| DUT         | 7422 (100 krad) |          |           |          | 7437 (100 krad) |          |           |          |
|-------------|-----------------|----------|-----------|----------|-----------------|----------|-----------|----------|
| Input Pin   | Pre-Irrad       | Post-Ann | Pre-Irrad | Post-Ann | Pre-Irrad       | Post-Ann | Pre-Irrad | Post-Ann |
|             | VIL (mV)        |          | VIH (mV)  |          | VIL (mV)        |          | VIH (mV)  |          |
| DA/QA0      | 1090            | 1165     | 1545      | 1490     | 1095            | 1215     | 1550      | 1475     |
| DAH/QA0H    | 1440            | 1460     | 1435      | 1445     | 1445            | 1465     | 1445      | 1420     |
| ENCNTRH/YO0 | 1470            | 1460     | 2030      | 1425     | 1460            | 1455     | 1995      | 1435     |
| IDII0/IDIO0 | 1450            | 1350     | 1420      | 1435     | 1460            | 1460     | 1430      | 1400     |
| IDII1/IDIO1 | 1515            | 1515     | 1450      | 1455     | 1510            | 1500     | 1450      | 1450     |
| IDII2/IDIO2 | 1335            | 1495     | 1415      | 1420     | 1495            | 1500     | 1450      | 1430     |
| IDII3/IDIO3 | 1520            | 1390     | 1430      | 1425     | 1515            | 1395     | 1430      | 1420     |
| IDII4/IDIO4 | 1480            | 1440     | 1455      | 1415     | 1465            | 1440     | 1455      | 1415     |
| IDII5/IDIO5 | 1300            | 1310     | 1425      | 1565     | 1415            | 1325     | 1520      | 1435     |
| IDII6/IDIO6 | 1390            | 1425     | 1440      | 1400     | 1390            | 1425     | 1455      | 1405     |
| IDII7/IDIO7 | 1490            | 1480     | 1420      | 1425     | 1460            | 1495     | 1420      | 1420     |

**Table 4b Pre-Irradiation and Post-Annealing Input Thresholds**

| DUT         | 7442 (60 krad) |          |           |          | 7459 (60 krad) |          |           |          |
|-------------|----------------|----------|-----------|----------|----------------|----------|-----------|----------|
| Input Pin   | Pre-Irrad      | Post-Ann | Pre-Irrad | Post-Ann | Pre-Irrad      | Post-Ann | Pre-Irrad | Post-Ann |
|             | VIL (mV)       |          | VIH (mV)  |          | VIL (mV)       |          | VIH (mV)  |          |
| DA/QA0      | 1110           | 1235     | 1550      | 1500     | 1125           | 1235     | 1495      | 1545     |
| DAH/QA0H    | 1460           | 1500     | 1455      | 1455     | 1455           | 1495     | 1420      | 1500     |
| ENCNTRH/YO0 | 1475           | 1450     | 2005      | 1430     | 1480           | 1490     | 2015      | 1925     |
| IDII0/IDIO0 | 1370           | 1420     | 1445      | 1430     | 1390           | 1495     | 1440      | 1470     |
| IDII1/IDIO1 | 1465           | 1460     | 1455      | 1440     | 1435           | 1515     | 1455      | 1450     |
| IDII2/IDIO2 | 1505           | 1500     | 1425      | 1420     | 1505           | 1455     | 1450      | 1450     |
| IDII3/IDIO3 | 1530           | 1535     | 1440      | 1420     | 1520           | 1500     | 1440      | 1425     |
| IDII4/IDIO4 | 1470           | 1460     | 1440      | 1430     | 1475           | 1480     | 1460      | 1465     |
| IDII5/IDIO5 | 1395           | 1345     | 1435      | 1565     | 1415           | 1375     | 1525      | 1575     |
| IDII6/IDIO6 | 1465           | 1460     | 1425      | 1405     | 1415           | 1470     | 1425      | 1445     |
| IDII7/IDIO7 | 1500           | 1525     | 1430      | 1425     | 1500           | 1480     | 1430      | 1425     |

**Table 4c Pre-Irradiation and Post-Annealing Input Thresholds**

| DUT         | 7508 (40 krad) |          |           |          | 7579 (40 krad) |          |           |          |
|-------------|----------------|----------|-----------|----------|----------------|----------|-----------|----------|
| Input Pin   | Pre-Irrad      | Post-Ann | Pre-Irrad | Post-Ann | Pre-Irrad      | Post-Ann | Pre-Irrad | Post-Ann |
|             | VIL (mV)       |          | VIH (mV)  |          | VIL (mV)       |          | VIH (mV)  |          |
| DA/QA0      | 1105           | 1195     | 1555      | 1550     | 1160           | 1225     | 1520      | 1550     |
| DAH/QA0H    | 1445           | 1475     | 1440      | 1485     | 1450           | 1510     | 1450      | 1505     |
| ENCNTRH/YO0 | 1475           | 1490     | 2025      | 1960     | 1490           | 1470     | 1960      | 1915     |
| IDII0/IDIO0 | 1370           | 1490     | 1440      | 1445     | 1375           | 1480     | 1440      | 1455     |
| IDII1/IDIO1 | 1515           | 1480     | 1450      | 1465     | 1505           | 1460     | 1460      | 1460     |
| IDII2/IDIO2 | 1415           | 1505     | 1445      | 1425     | 1370           | 1495     | 1430      | 1430     |
| IDII3/IDIO3 | 1525           | 1530     | 1435      | 1440     | 1550           | 1530     | 1440      | 1435     |
| IDII4/IDIO4 | 1465           | 1455     | 1455      | 1405     | 1475           | 1395     | 1460      | 1460     |
| IDII5/IDIO5 | 1390           | 1335     | 1425      | 1455     | 1385           | 1375     | 1455      | 1575     |
| IDII6/IDIO6 | 1410           | 1460     | 1450      | 1455     | 1410           | 1460     | 1430      | 1450     |
| IDII7/IDIO7 | 1475           | 1515     | 1440      | 1525     | 1510           | 1510     | 1525      | 1435     |

## E. Output-Drive Voltage (VOL/VOH)

The pre-irradiation and post-annealing VOL/VOH are listed in Tables 5 and 6. The post-annealing data are within the specification limits.

**Table 5 Pre-Irradiation and Post-Annealing VOL (mV) at Various Sinking Current**

| Sourcing Current | 7422 (100 krad) |         | 7437 (100 krad) |         | 7442 (60 krad) |         | 7459 (60 krad) |         | 7508 (40 krad) |         | 7579 (40 krad) |         |
|------------------|-----------------|---------|-----------------|---------|----------------|---------|----------------|---------|----------------|---------|----------------|---------|
|                  | Pre-rad         | Post-an | Pre-rad         | Post-an | Pre-rad        | Post-an | Pre-rad        | Post-an | Pre-rad        | Post-an | Pre-rad        | Post-an |
| 1 mA             | 10              | 10      | 10              | 10      | 10             | 10      | 10             | 10      | 10             | 10      | 10             | 10      |
| 12 mA            | 115             | 115     | 114             | 113     | 117            | 116     | 117            | 115     | 117            | 115     | 115            | 115     |
| 20 mA            | 193             | 192     | 189             | 189     | 195            | 193     | 194            | 192     | 193            | 193     | 192            | 192     |
| 50 mA            | 484             | 483     | 477             | 475     | 490            | 487     | 489            | 483     | 488            | 486     | 485            | 483     |
| 100 mA           | 992             | 989     | 977             | 975     | 1001           | 998     | 1001           | 990     | 999            | 995     | 993            | 989     |

**Table 6 Pre-Irradiation and Post-Annealing VOH (mV) at Various Sourcing Current**

| Sourcing Current | 7422 (100 krad) |         | 7437 (100 krad) |         | 7442 (60 krad) |         | 7459 (60 krad) |         | 7508 (40 krad) |         | 7579 (40 krad) |         |
|------------------|-----------------|---------|-----------------|---------|----------------|---------|----------------|---------|----------------|---------|----------------|---------|
|                  | Pre-rad         | Post-an | Pre-rad         | Post-an | Pre-rad        | Post-an | Pre-rad        | Post-an | Pre-rad        | Post-an | Pre-rad        | Post-an |
| 1 mA             | 4979            | 4971    | 4979            | 4965    | 4980           | 4975    | 4980           | 4977    | 4979           | 4977    | 4979           | 4977    |
| 8 mA             | 4850            | 4839    | 4850            | 4833    | 4850           | 4845    | 4851           | 4848    | 4850           | 4847    | 4851           | 4848    |
| 20 mA            | 4623            | 4609    | 4623            | 4601    | 4623           | 4616    | 4624           | 4620    | 4622           | 4618    | 4624           | 4620    |
| 50 mA            | 4011            | 3985    | 4008            | 3971    | 4013           | 4001    | 4014           | 4007    | 4010           | 4002    | 4013           | 4007    |
| 100 mA           | 2647            | 2560    | 2624            | 2493    | 2669           | 2631    | 2666           | 2637    | 2646           | 2623    | 2658           | 2638    |

## F. Propagation Delay

Table 7 lists the pre-irradiation and post-annealing propagation delays, and also lists the radiation-induced degradations in percentage. The radiation delta in every case is well within the 10% degradation criterion. The user can take the worst case for the design-margin consideration.

**Table 7 Radiation-Induced Propagation-Delay Degradations**

| DUT  | Total Dose | Pre-Irradiation (μs) | Post-Anneal (μs) | Degradation (%) |
|------|------------|----------------------|------------------|-----------------|
| 7422 | 100 krad   | 1.37                 | 1.48             | 8.42%           |
| 7437 | 100 krad   | 1.38                 | 1.50             | 9.09%           |
| 7442 | 60 krad    | 1.35                 | 1.37             | 1.48%           |
| 7459 | 60 krad    | 1.35                 | 1.36             | 0.74%           |
| 7508 | 40 krad    | 1.36                 | 1.36             | 0.00%           |
| 7579 | 40 krad    | 1.38                 | 1.38             | 0.00%           |

## G. Transition Characteristics

Figure 9a to Figure 20b show the pre-irradiation and post-annealing transition edges. In each case, the radiation-induced transition-time degradation is insignificant.

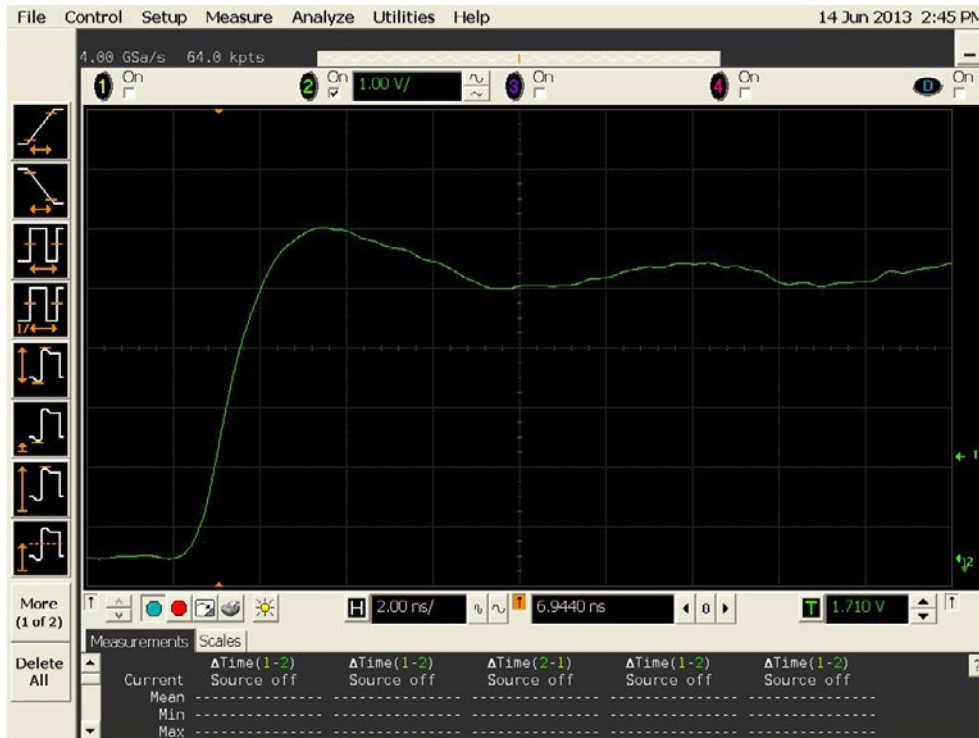


Figure 9a DUT 7422 Pre-Irradiation Rising Edge

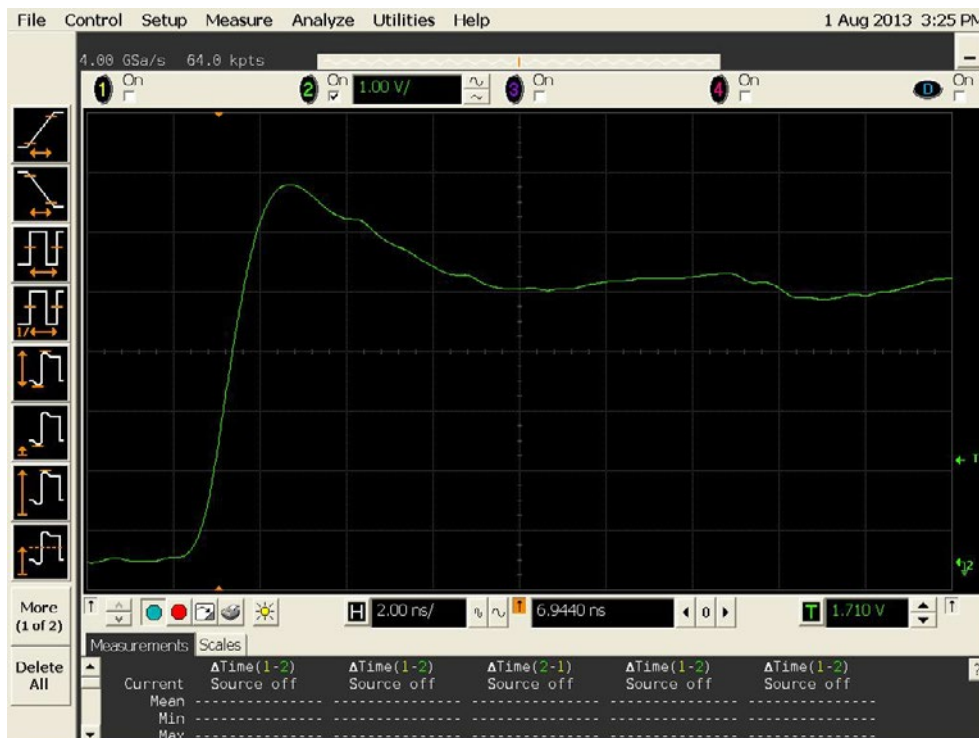


Figure 9b DUT 7422 Post-Annealing Rising Edge

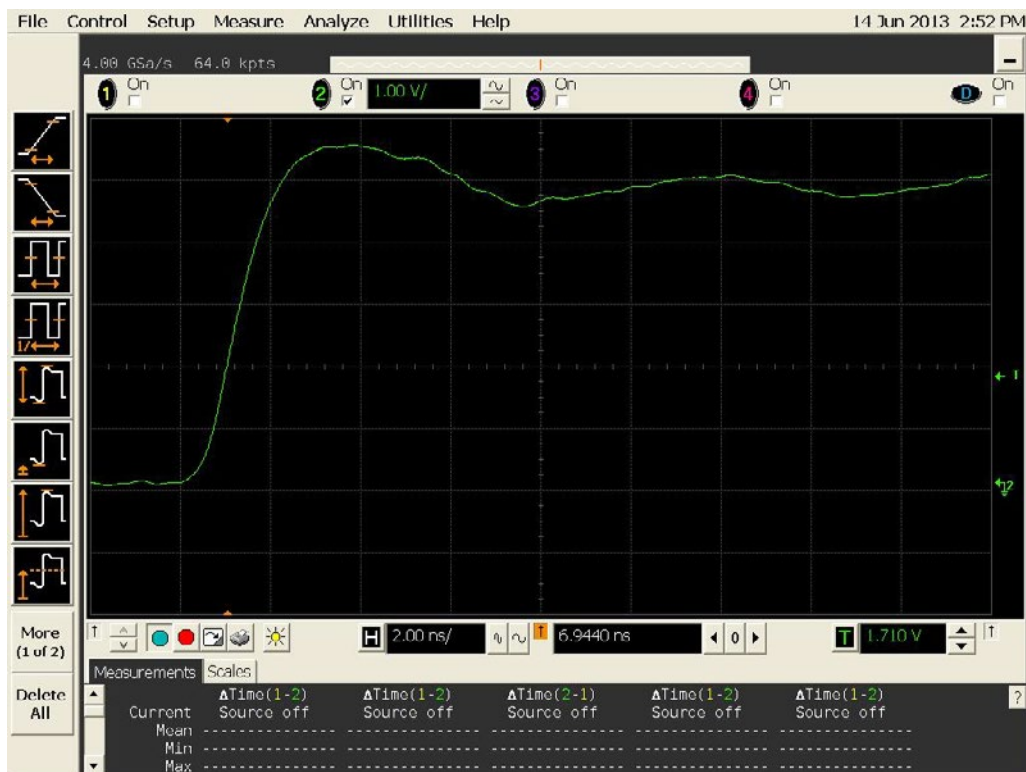


Figure 10a DUT 7437 Pre-Irradiation Rising Edge

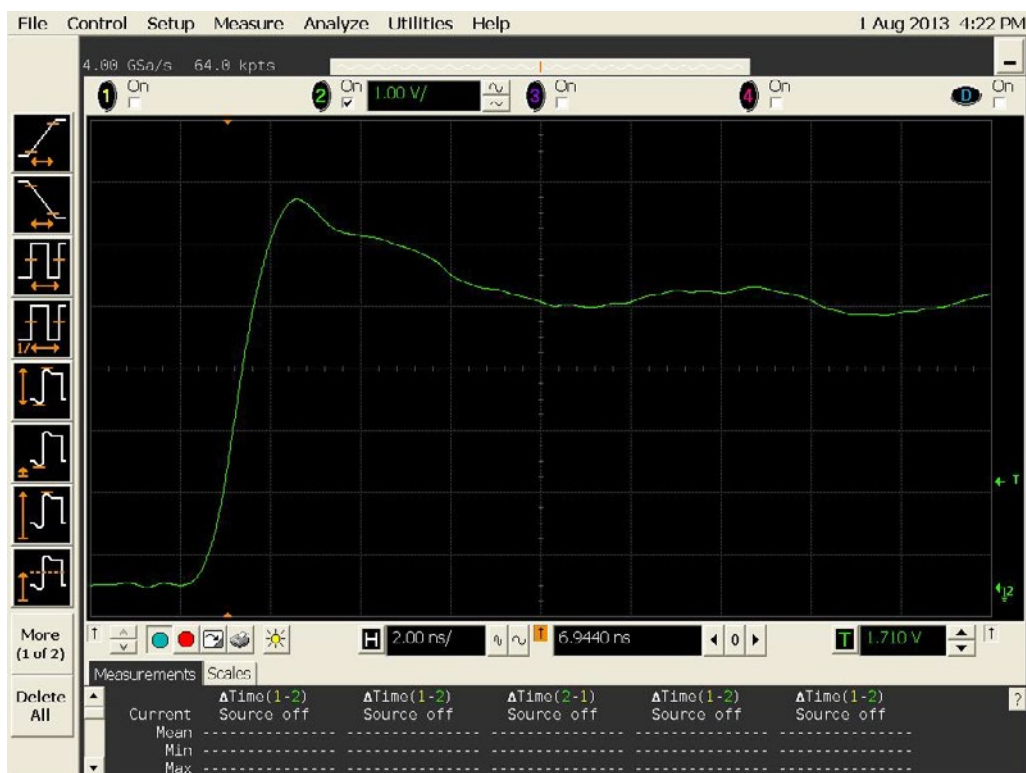


Figure 10b DUT 7437 Post-Annealing Rising Edge

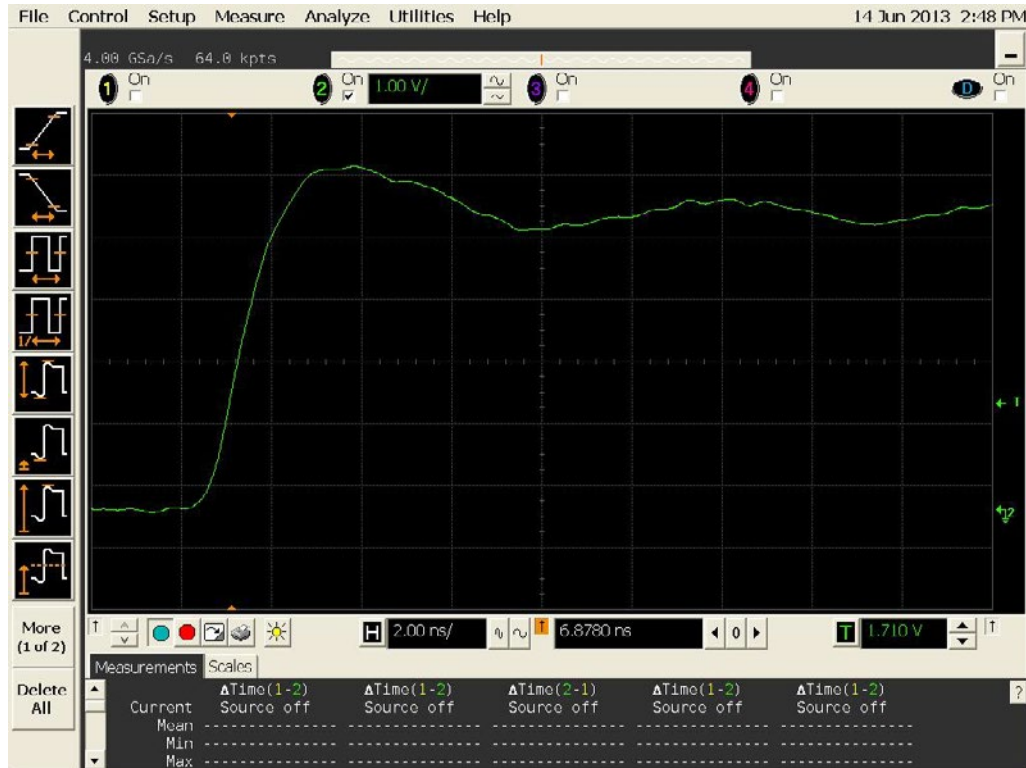


Figure 11a DUT 7442 Pre-Radiation Rising Edge

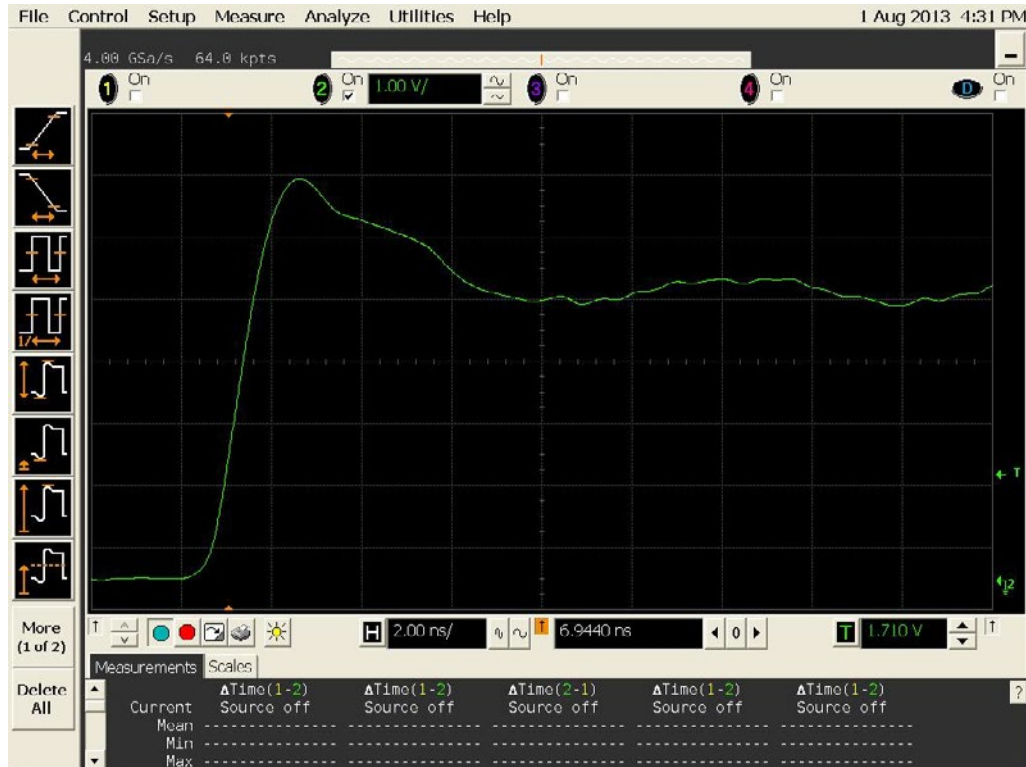


Figure 11b DUT 7442 Post-Annealing Rising edge



Figure 12a DUT 7459 Pre-Irradiation Rising Edge

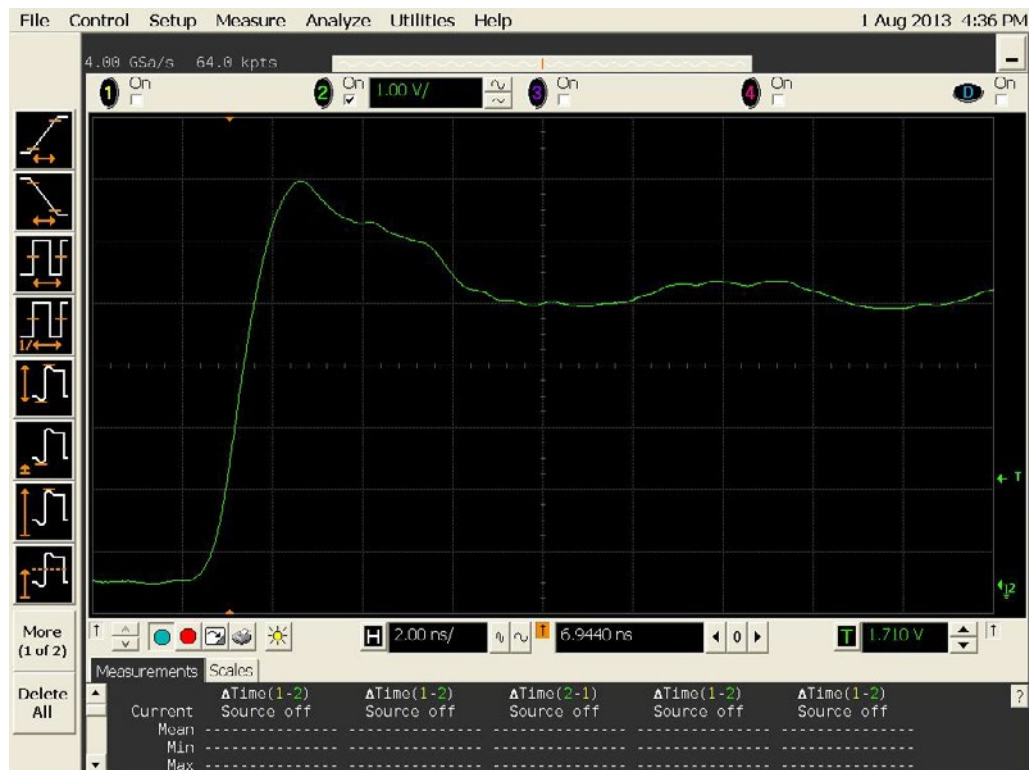


Figure 12b DUT 7459 Post-Annealing Rising Edge

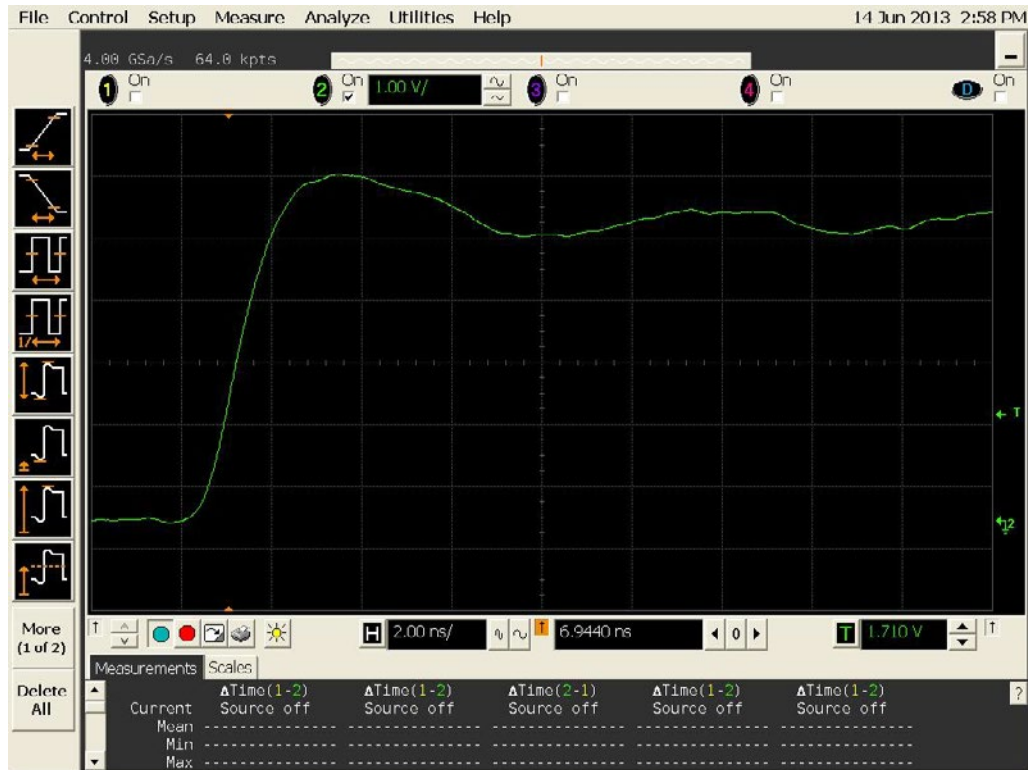


Figure 13a DUT 7508 Pre-Irradiation Rising Edge

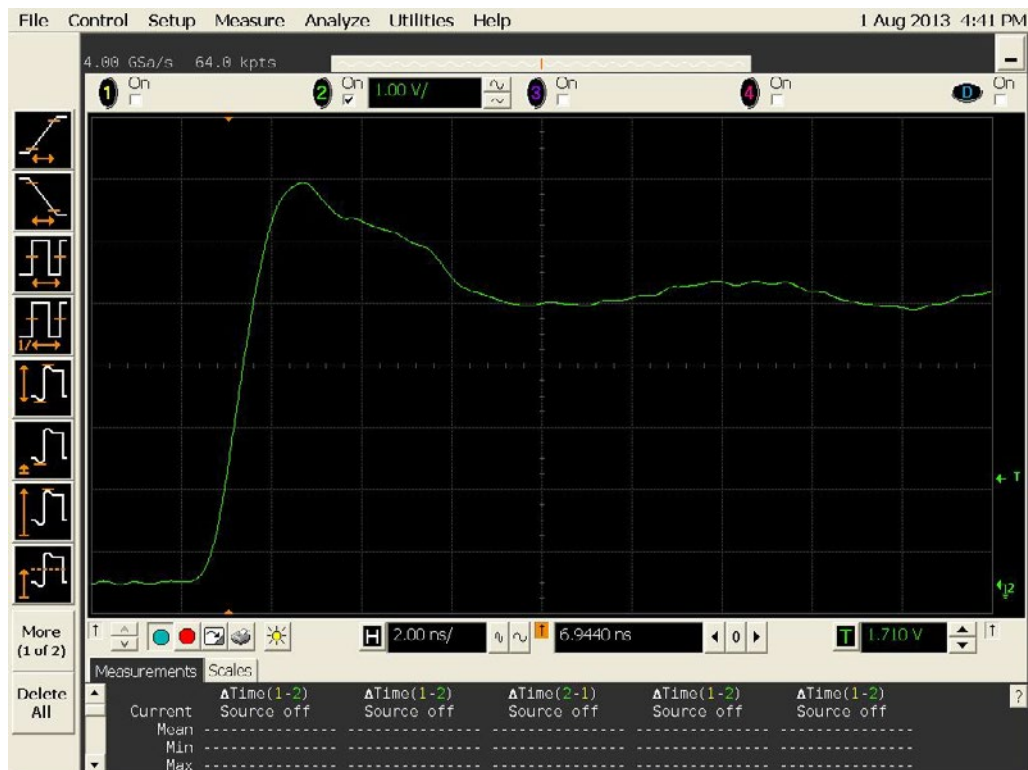


Figure 13b DUT 7508 Post-Annealing Rising Edge

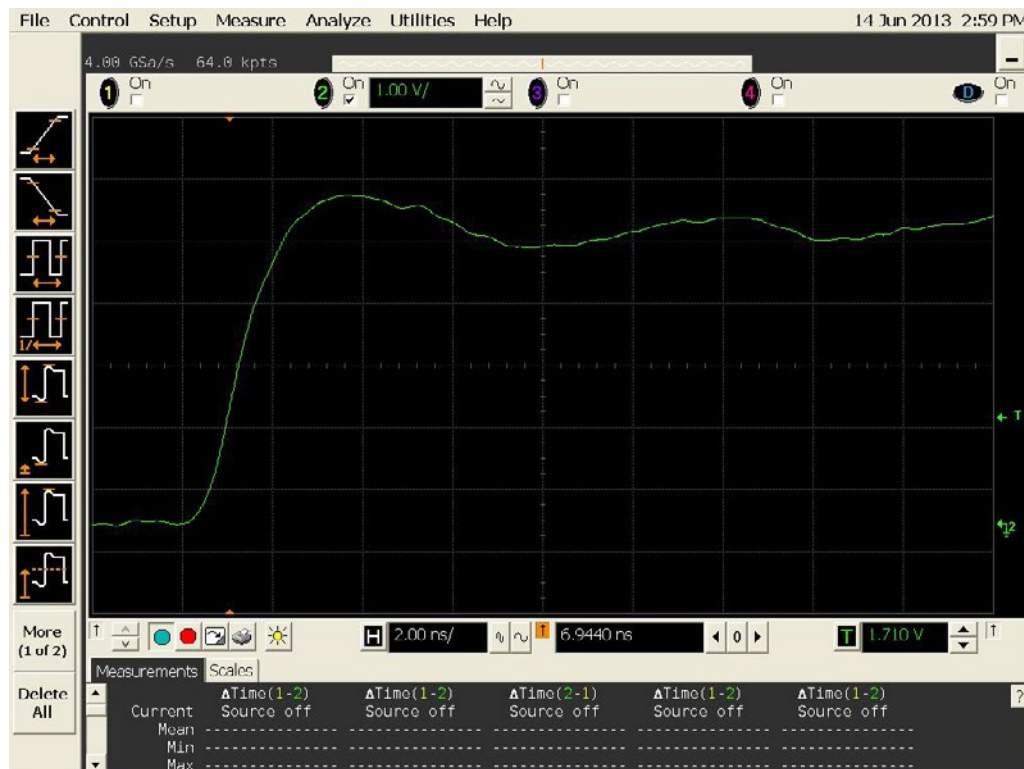


Figure 14a DUT 7579 Pre-Irradiation Rising Edge

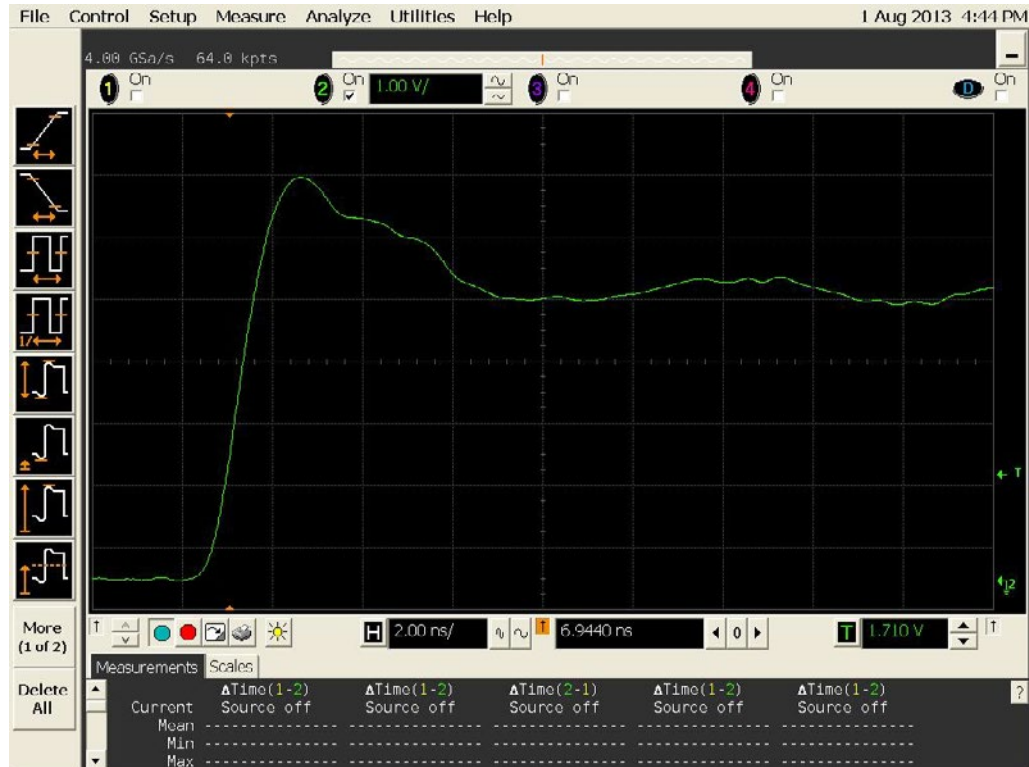


Figure 14b DUT 7579 Post-Annealing Rising Edge

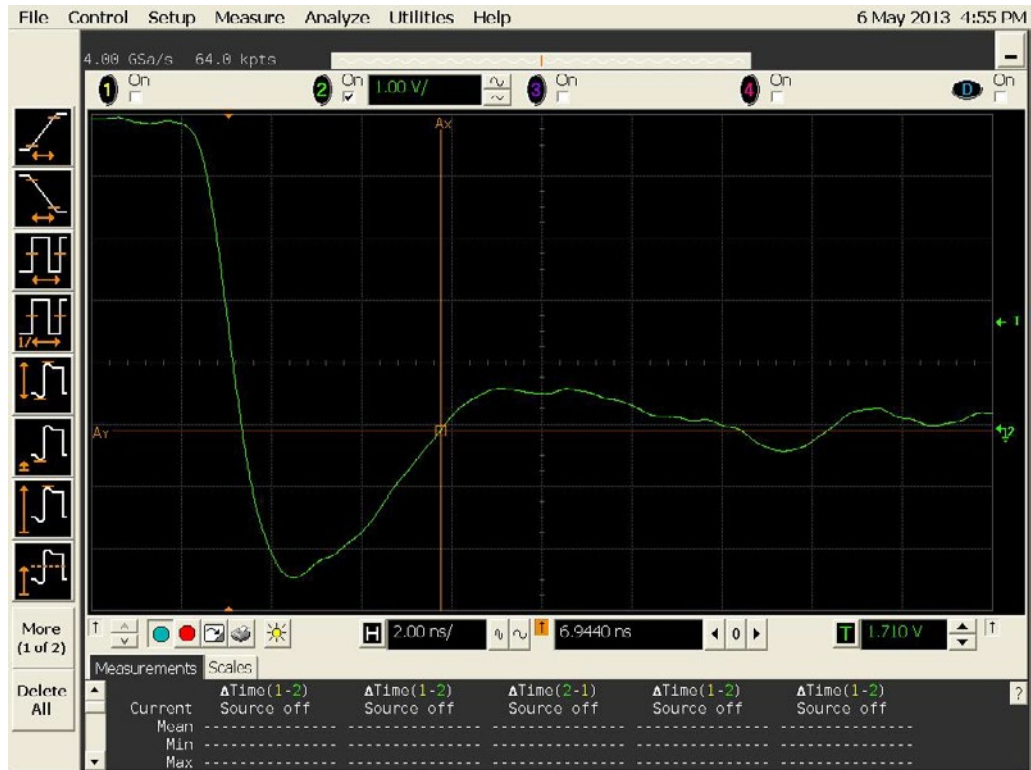


Figure 15a DUT 7422 Pre-Radiation Falling Edge

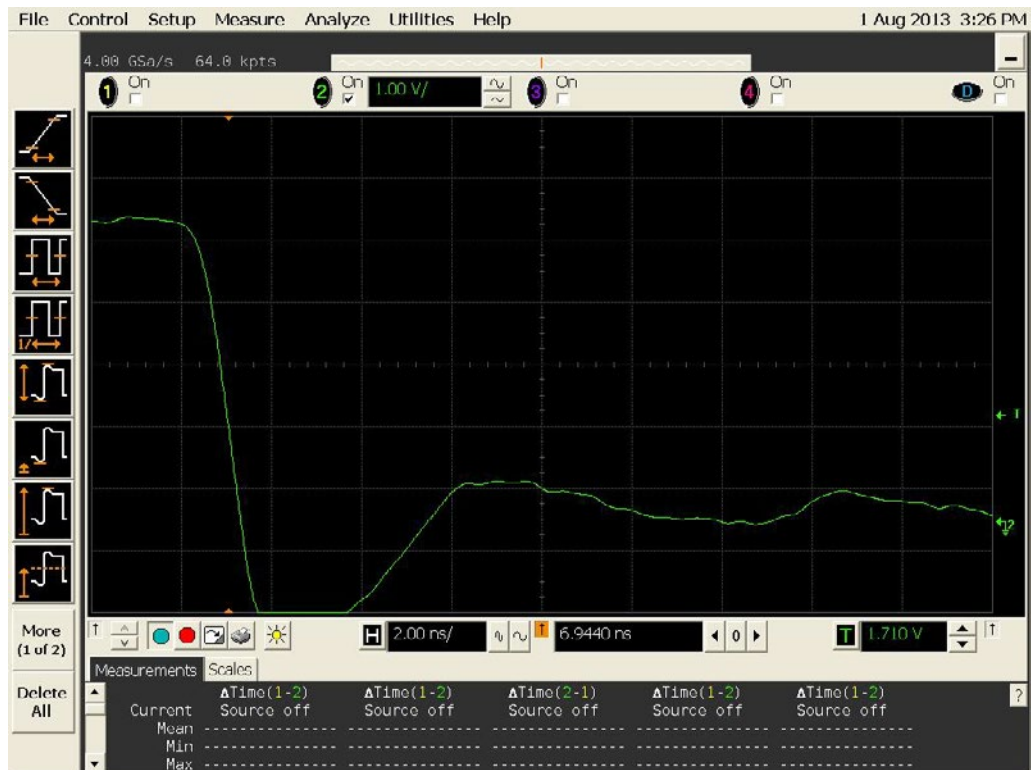


Figure 15b DUT 7422 Post-Annealing Falling Edge



Figure 16a DUT 7437 Pre-Irradiation Falling Edge



Figure 16b DUT 7437 Post-Annealing Falling Edge



Figure 17a DUT 7442 Pre-Irradiation Falling Edge



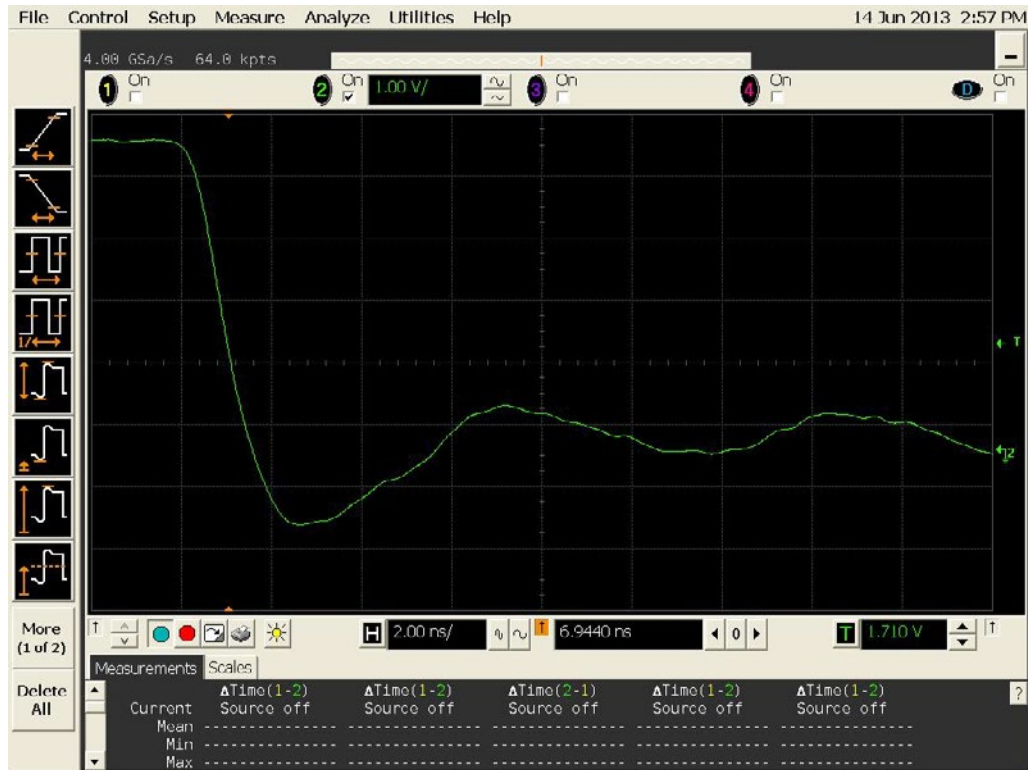
Figure 17b DUT 7442 Post-Annealing Falling Edge



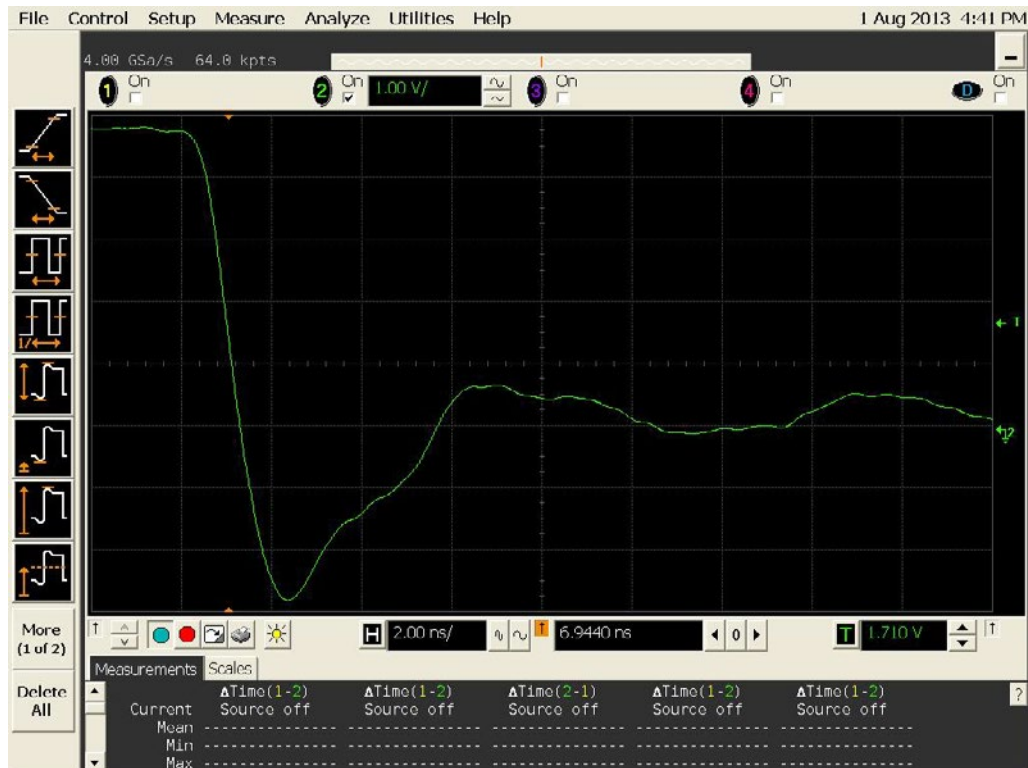
Figure 18a DUT 7459 Pre-Irradiation Falling Edge



Figure 18b DUT 7459 Post-Annealing Falling Edge



**Figure 19a DUT 7508 Pre-Irradiation Falling Edge**



**Figure 19b DUT 7508 Post-Annealing Falling Edge**

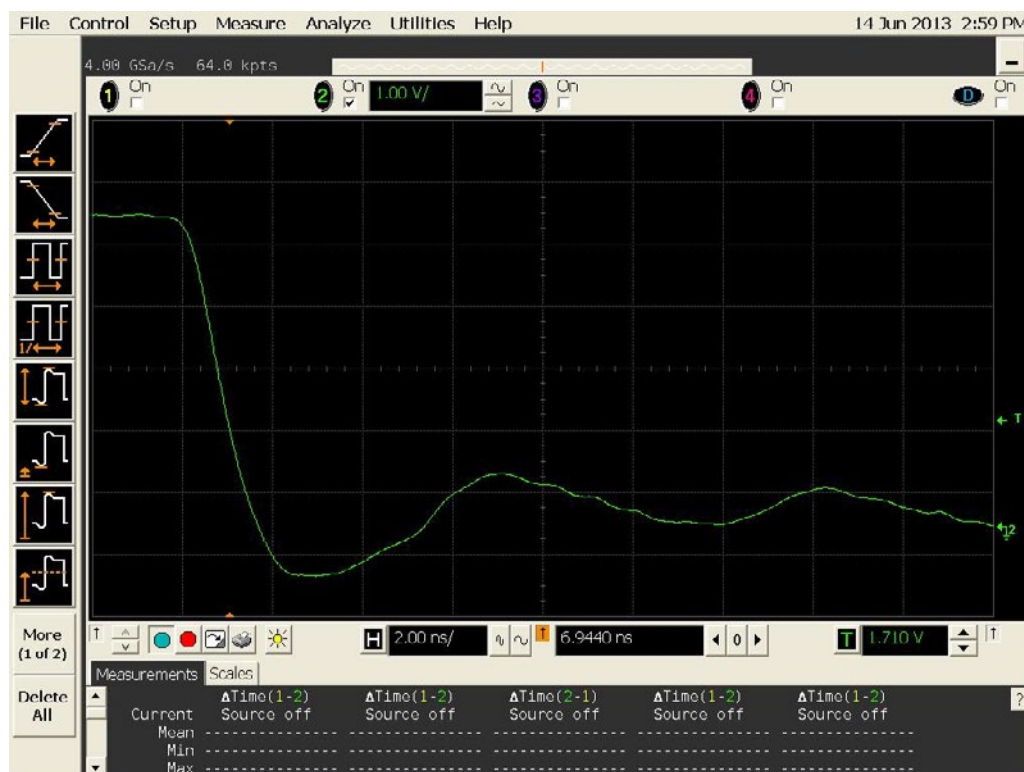


Figure 20a DUT 7579 Pre-Irradiation Falling Edge

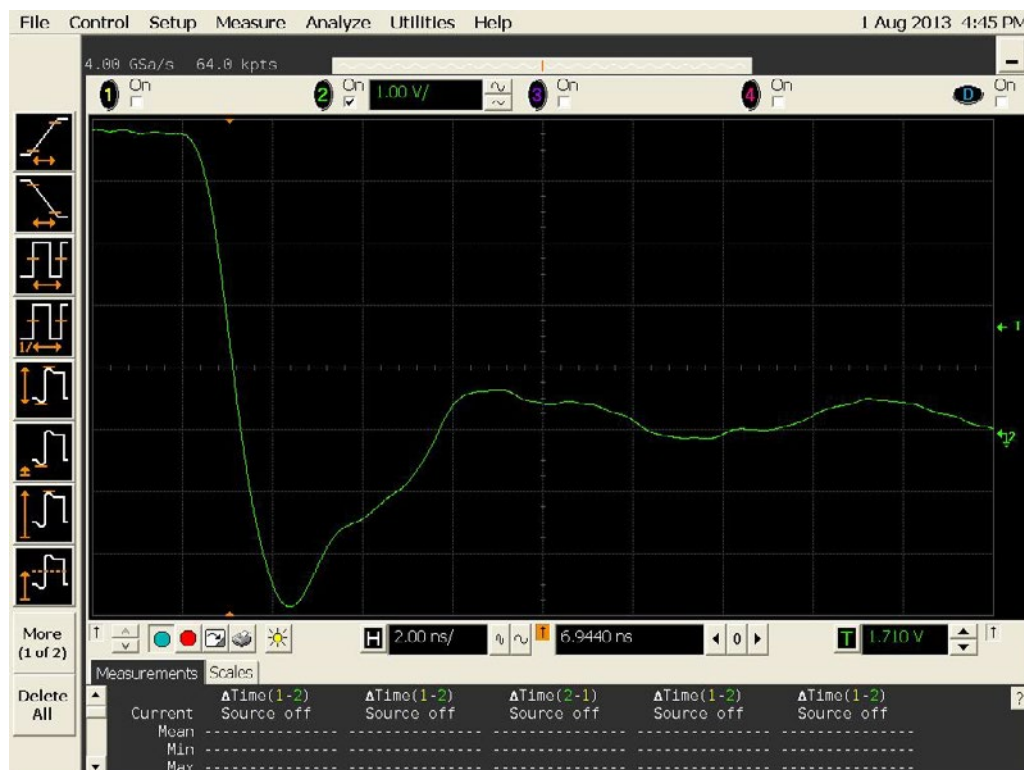


Figure 20b DUT 7579 Post-Annealing Falling Edge



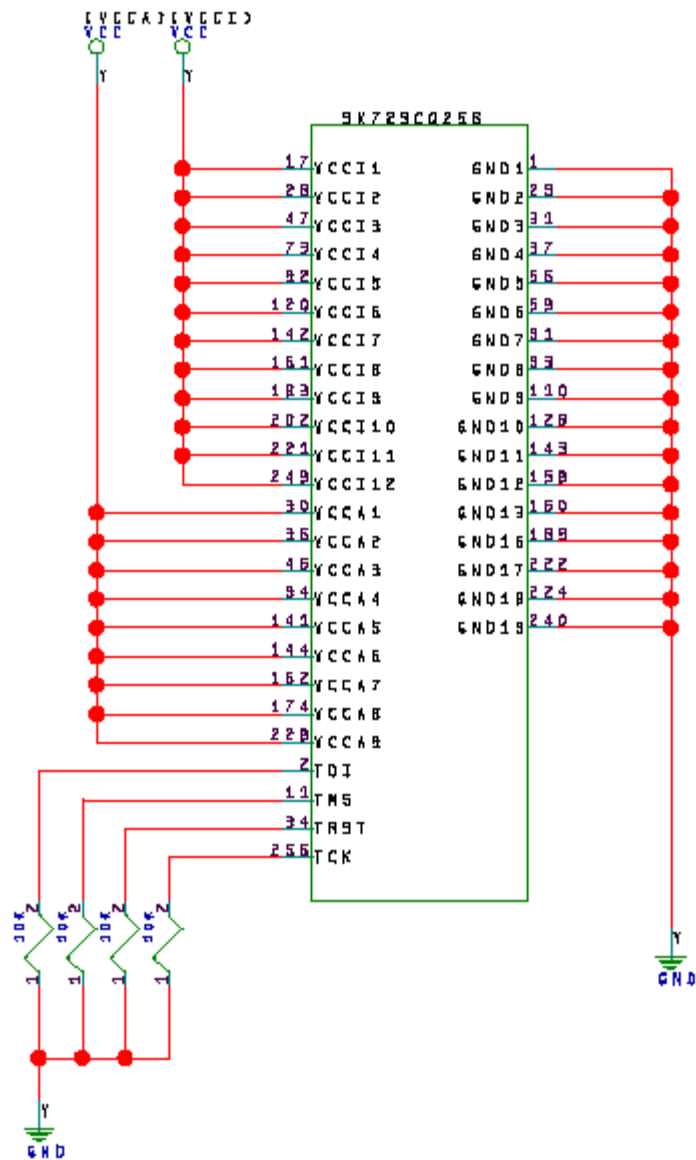
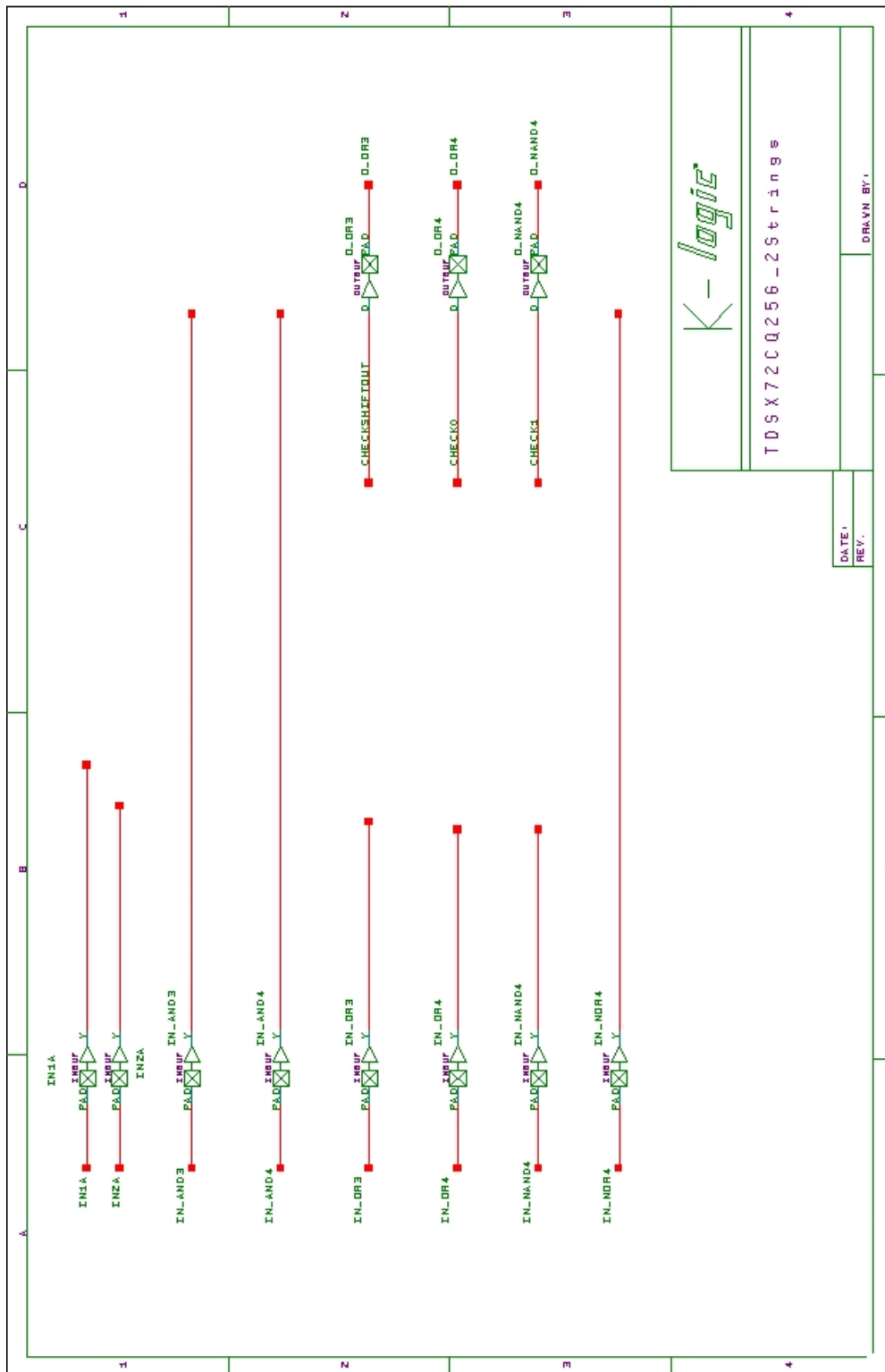
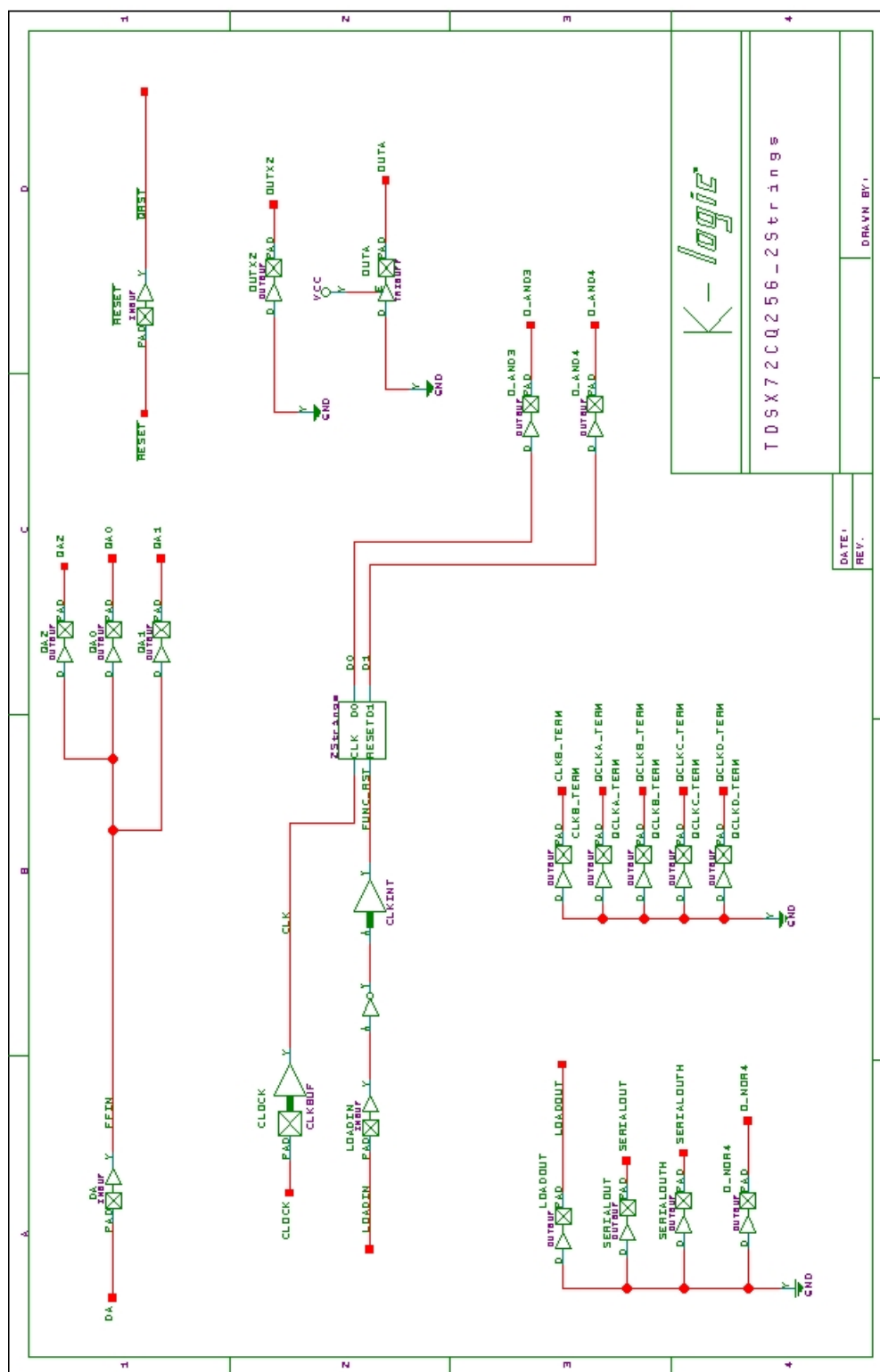
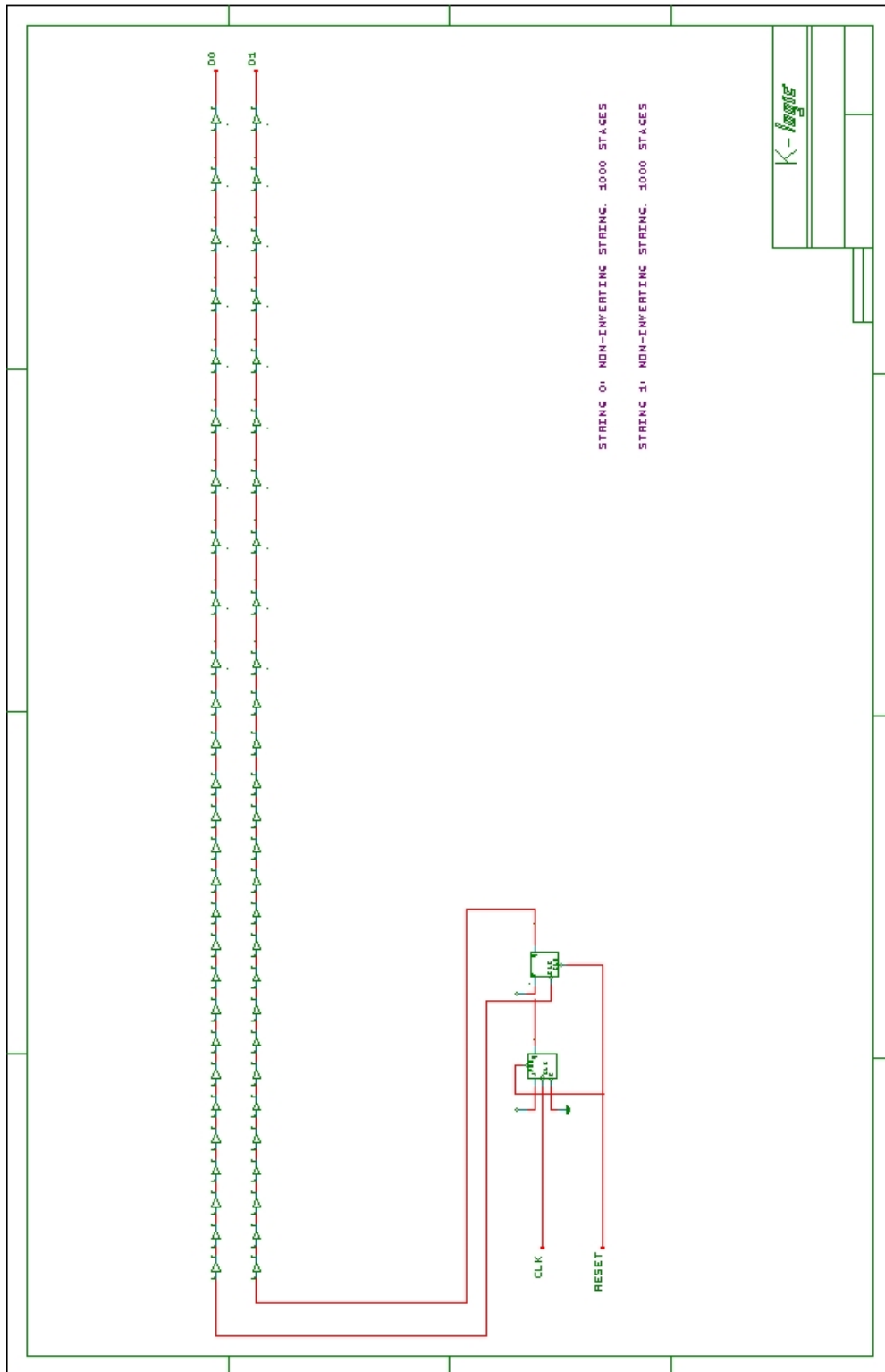


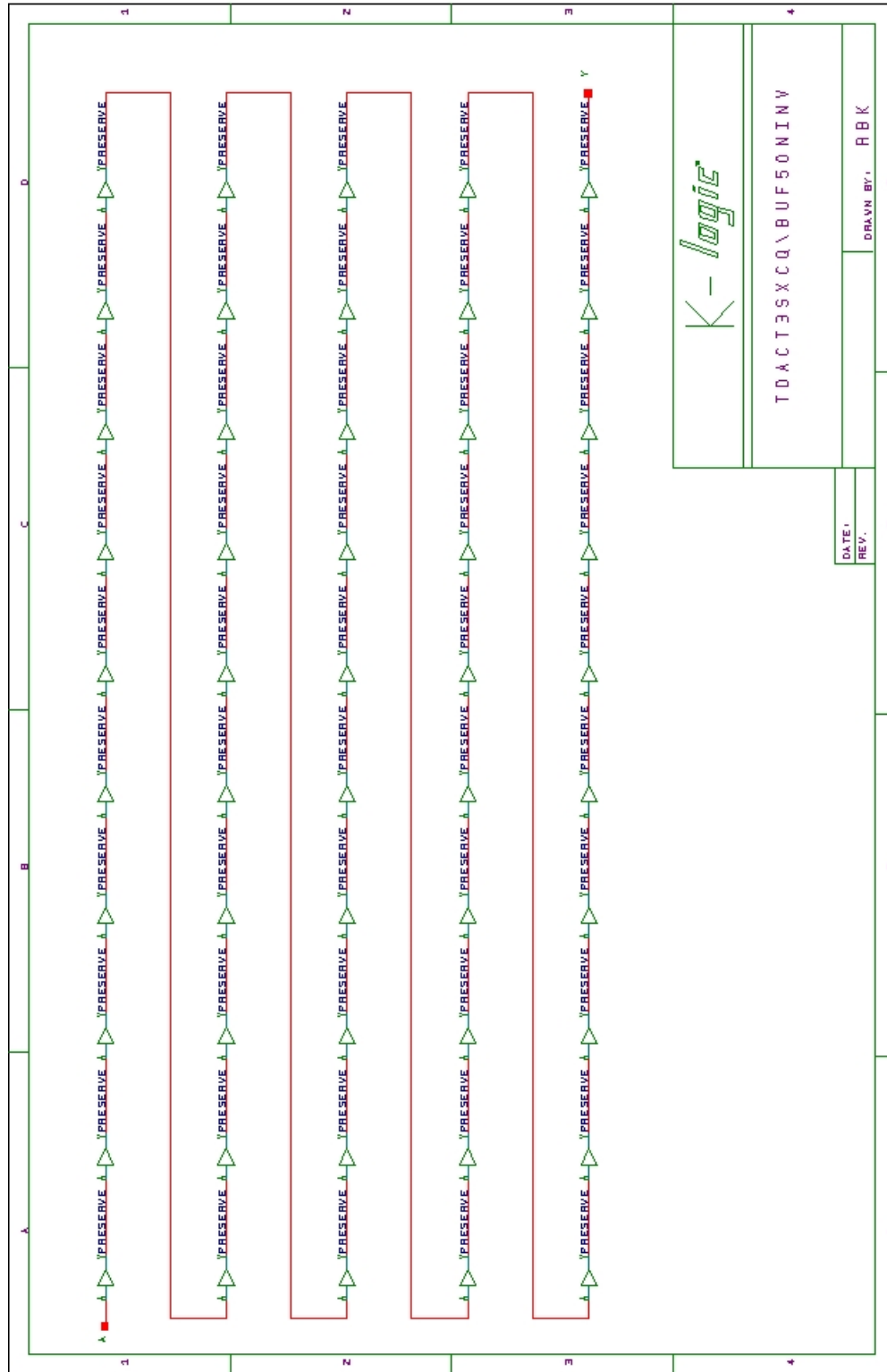
Figure A2 Power Supply, Ground and Special Pins Bias During Irradiation

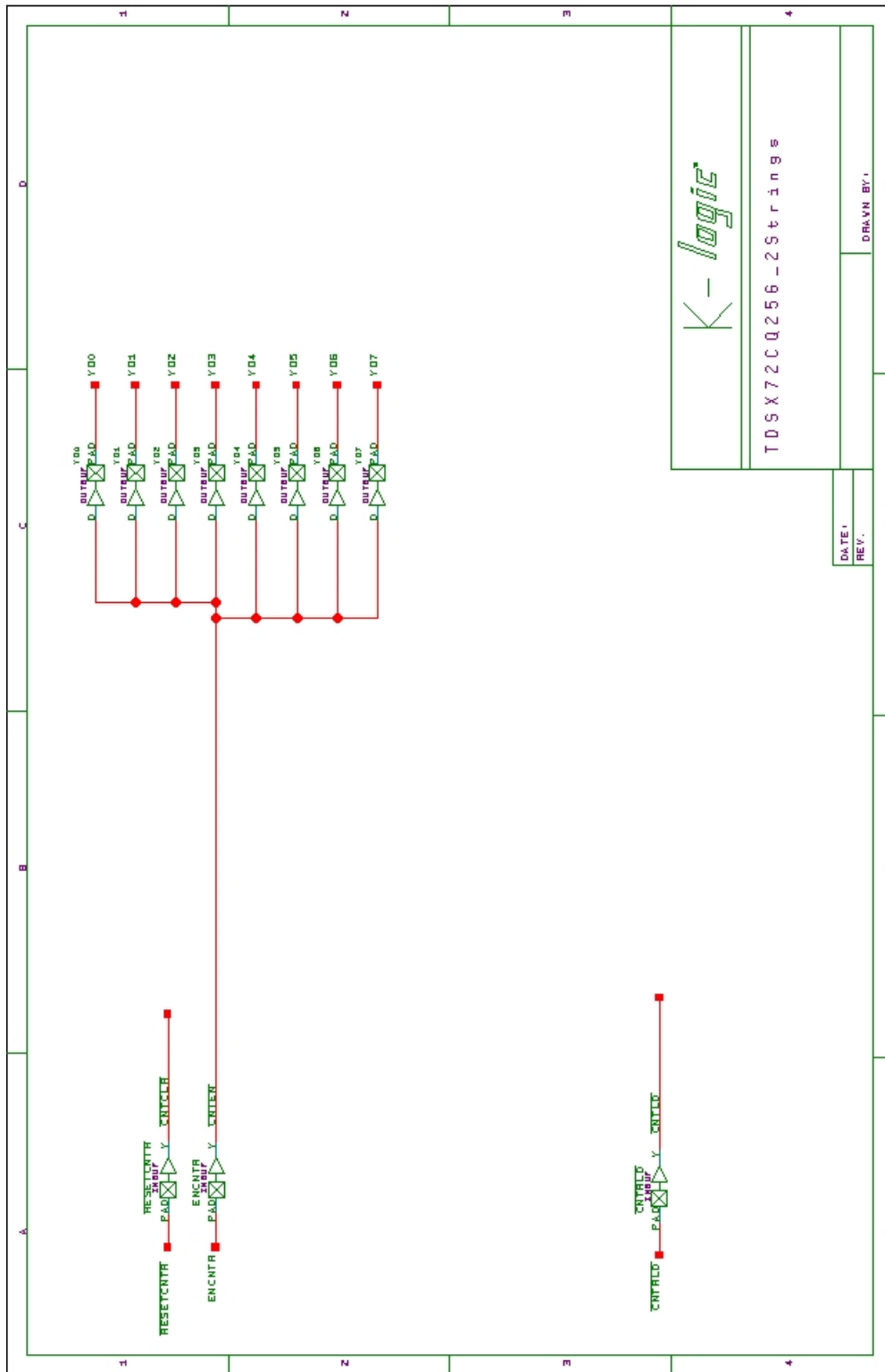
## Appendix B: DUT Design Schematics

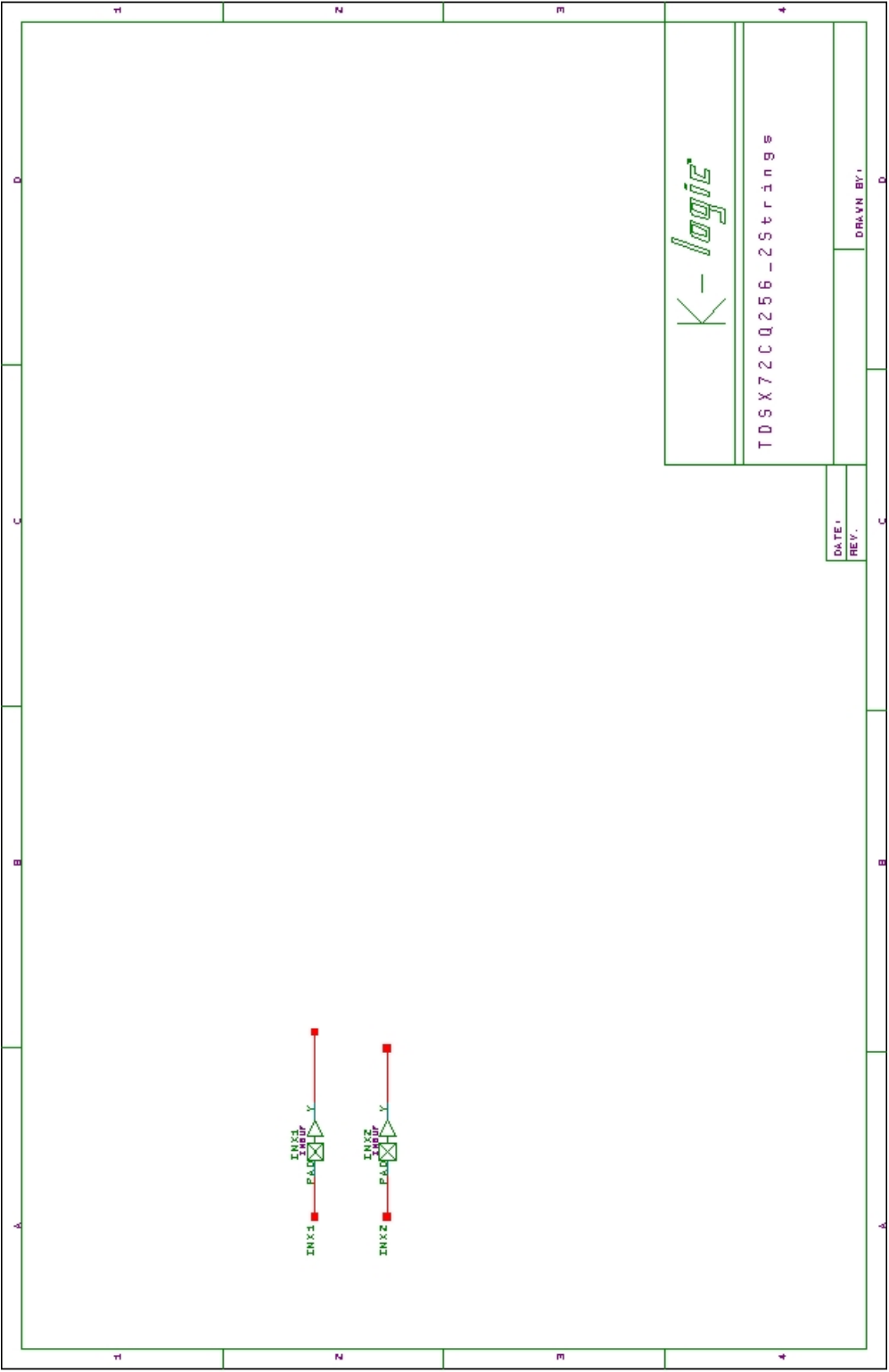










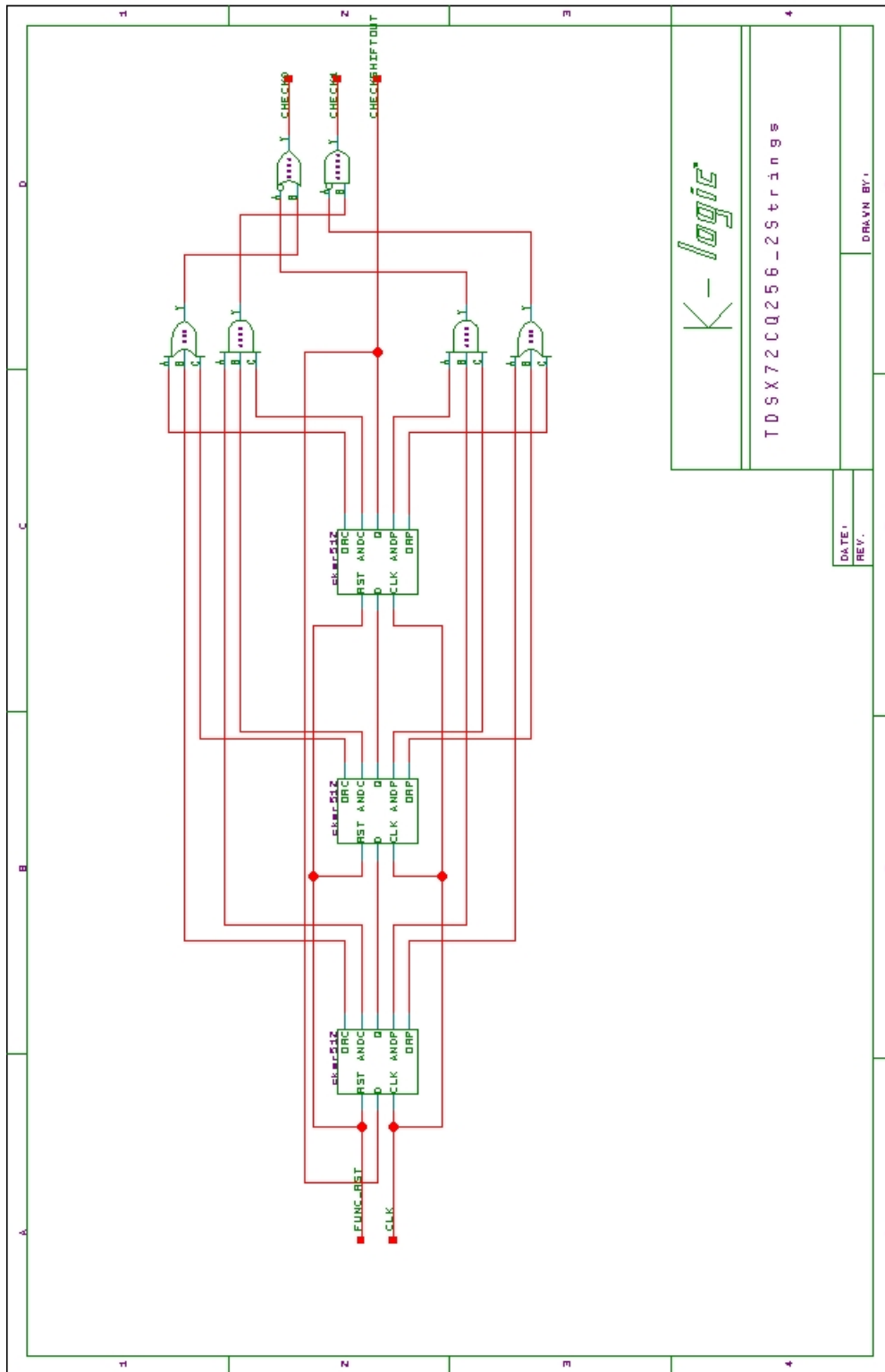


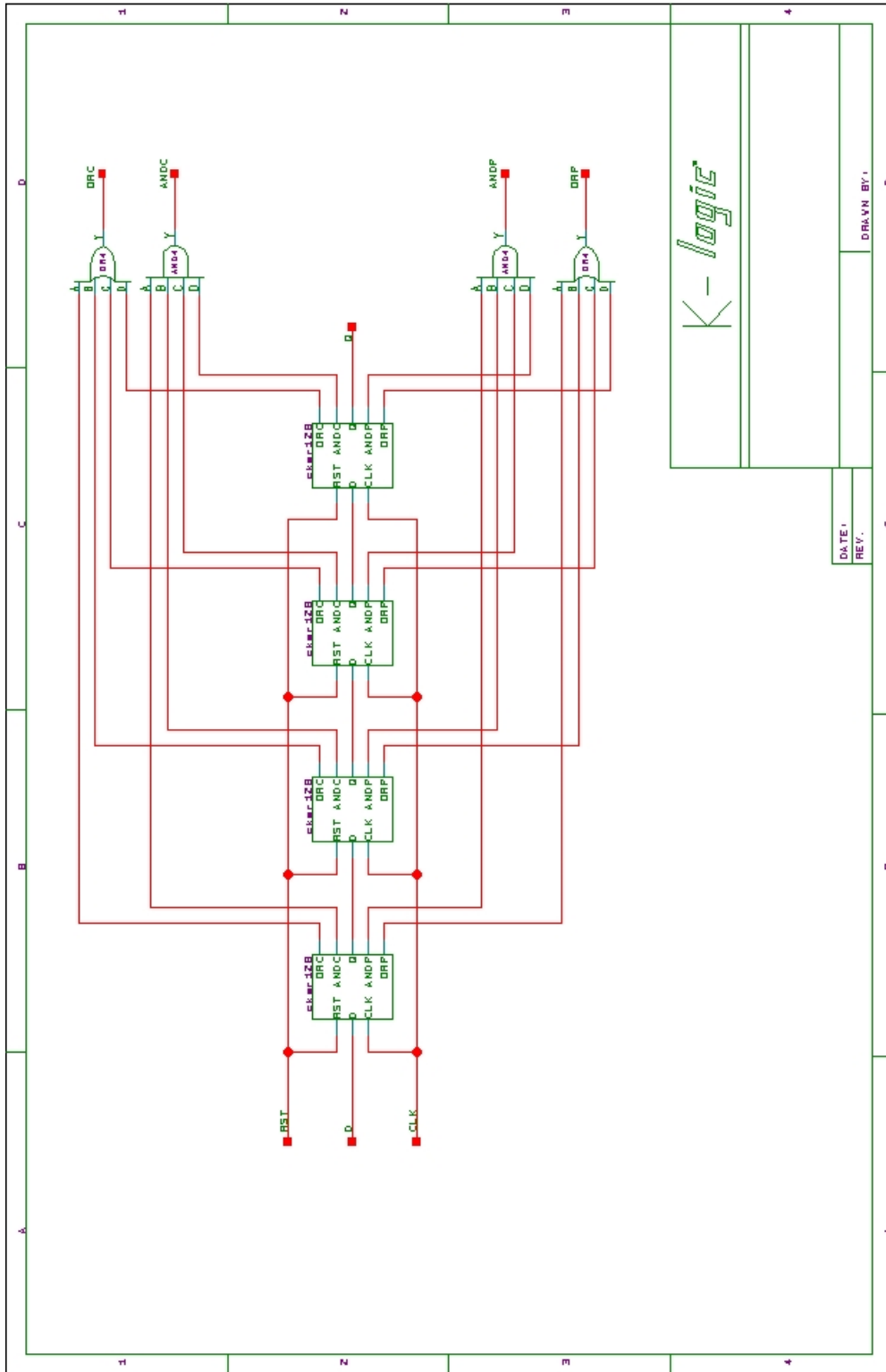
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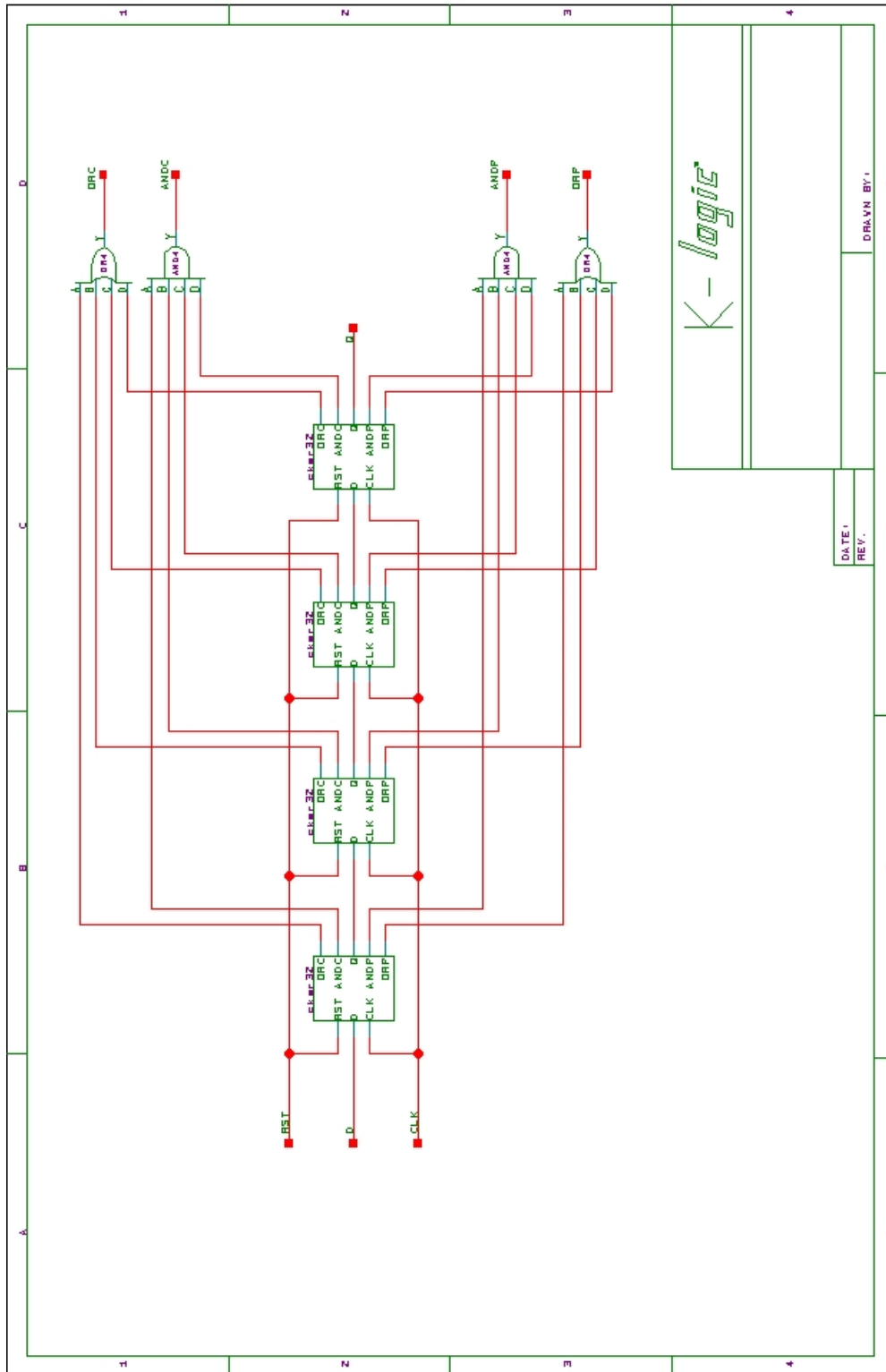
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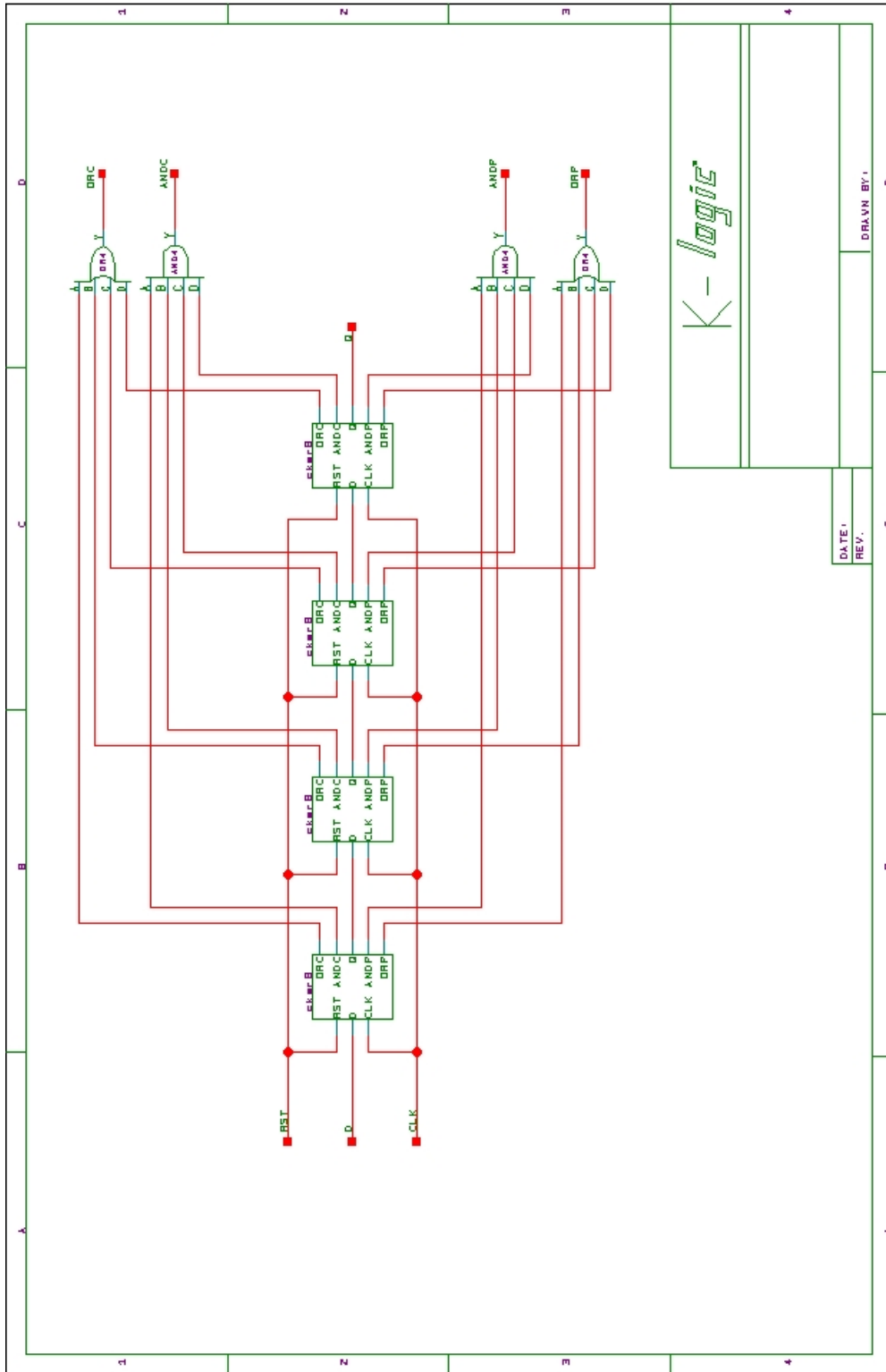
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REV.:

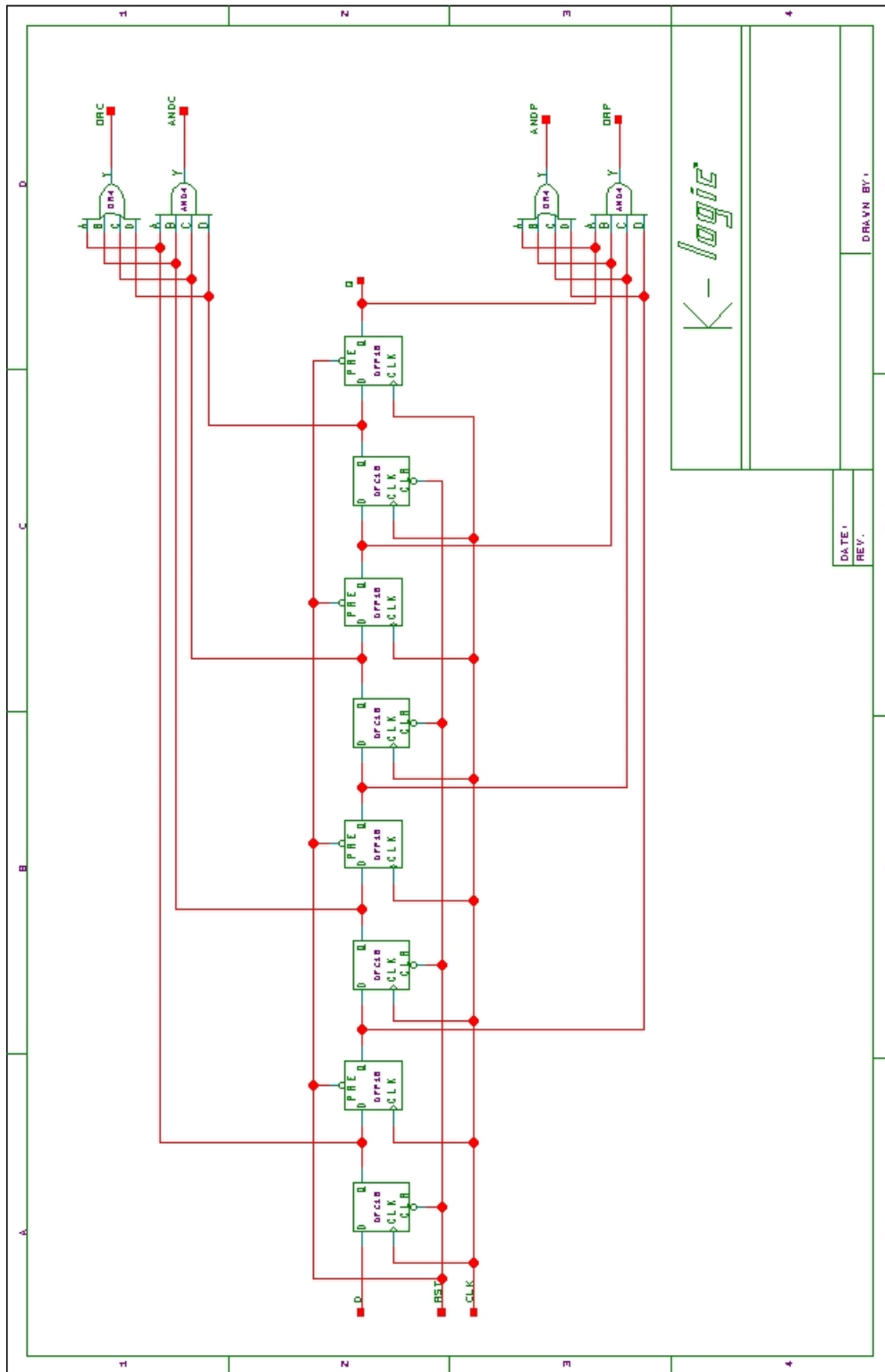
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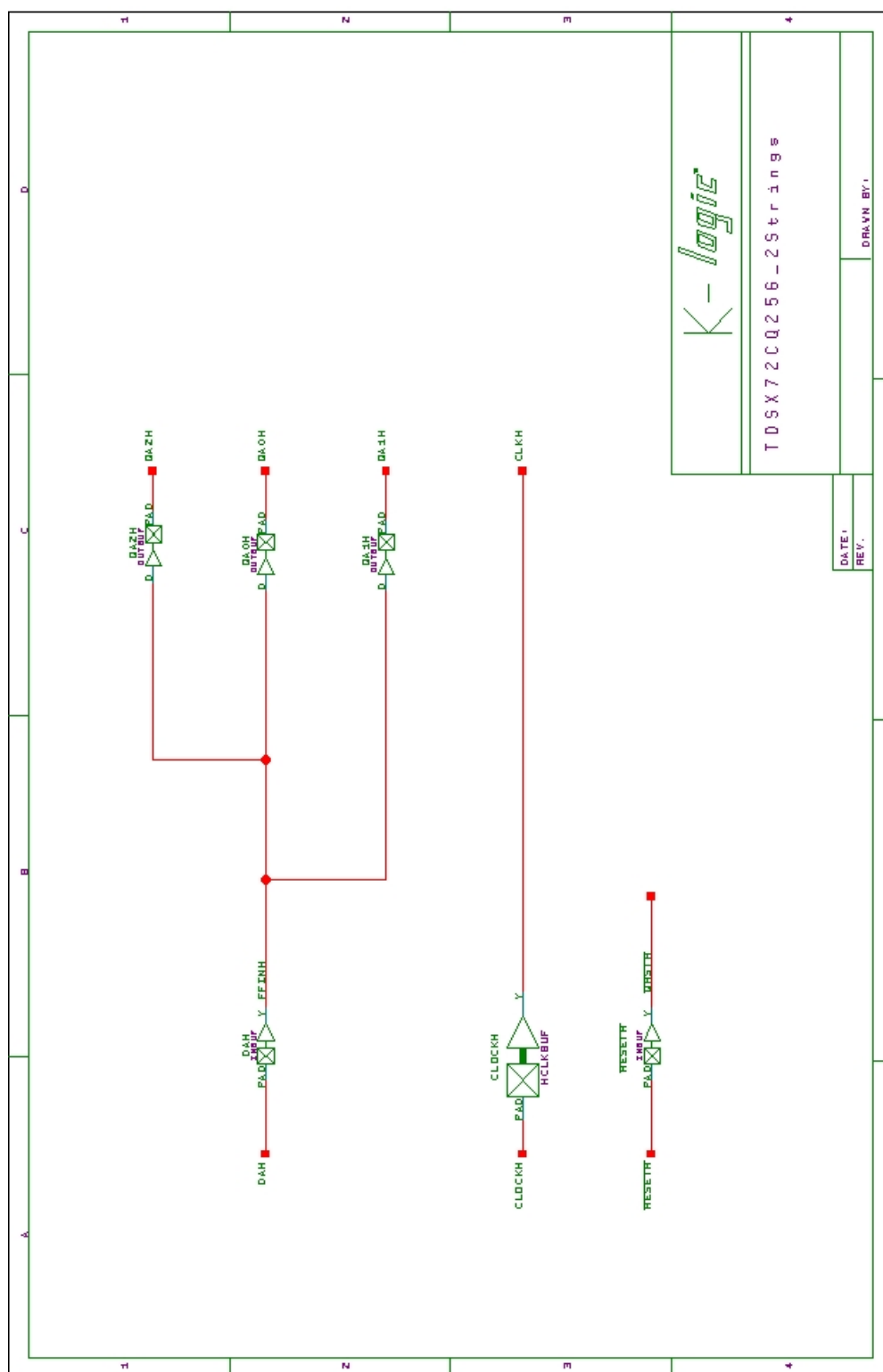


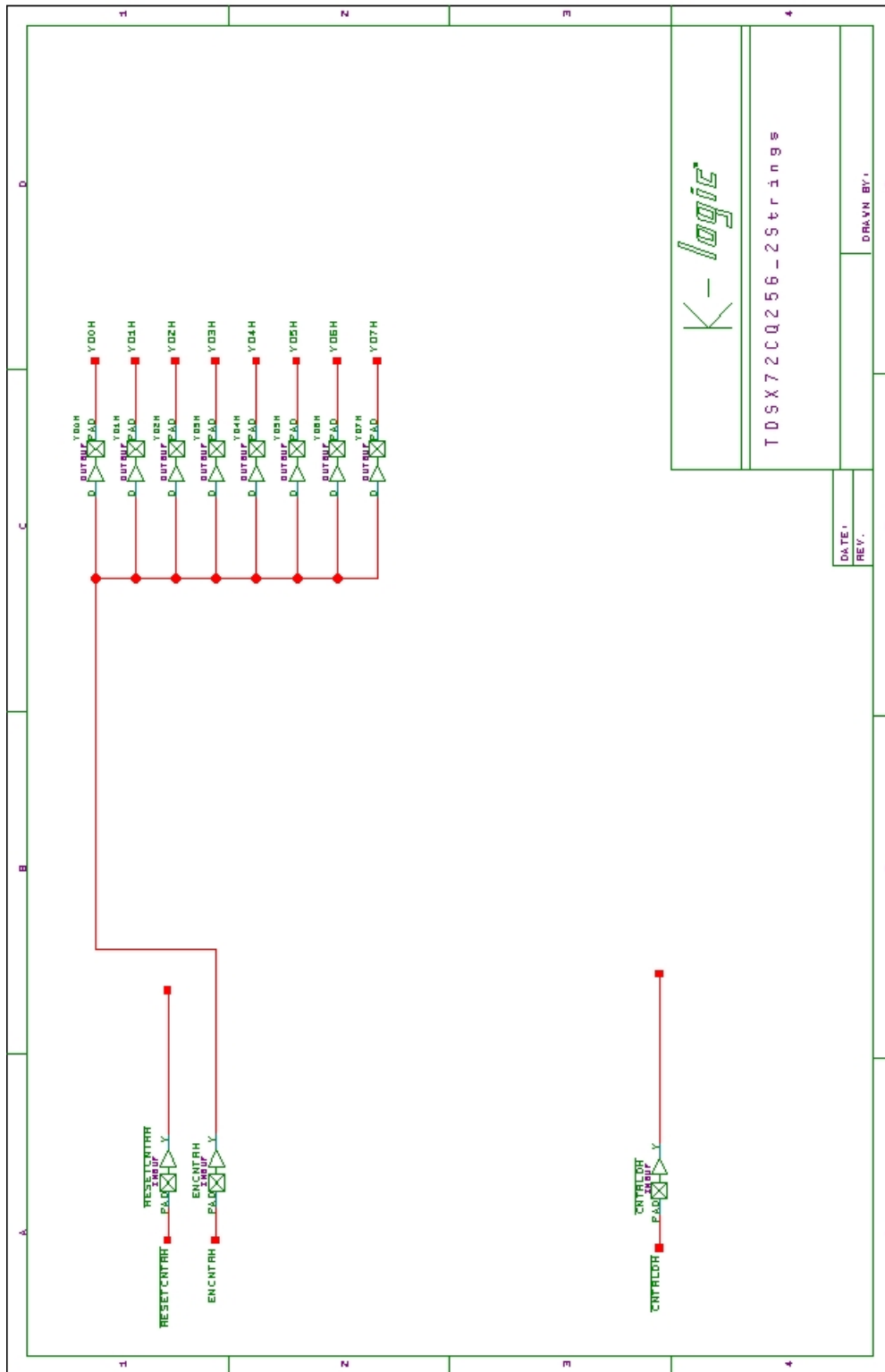


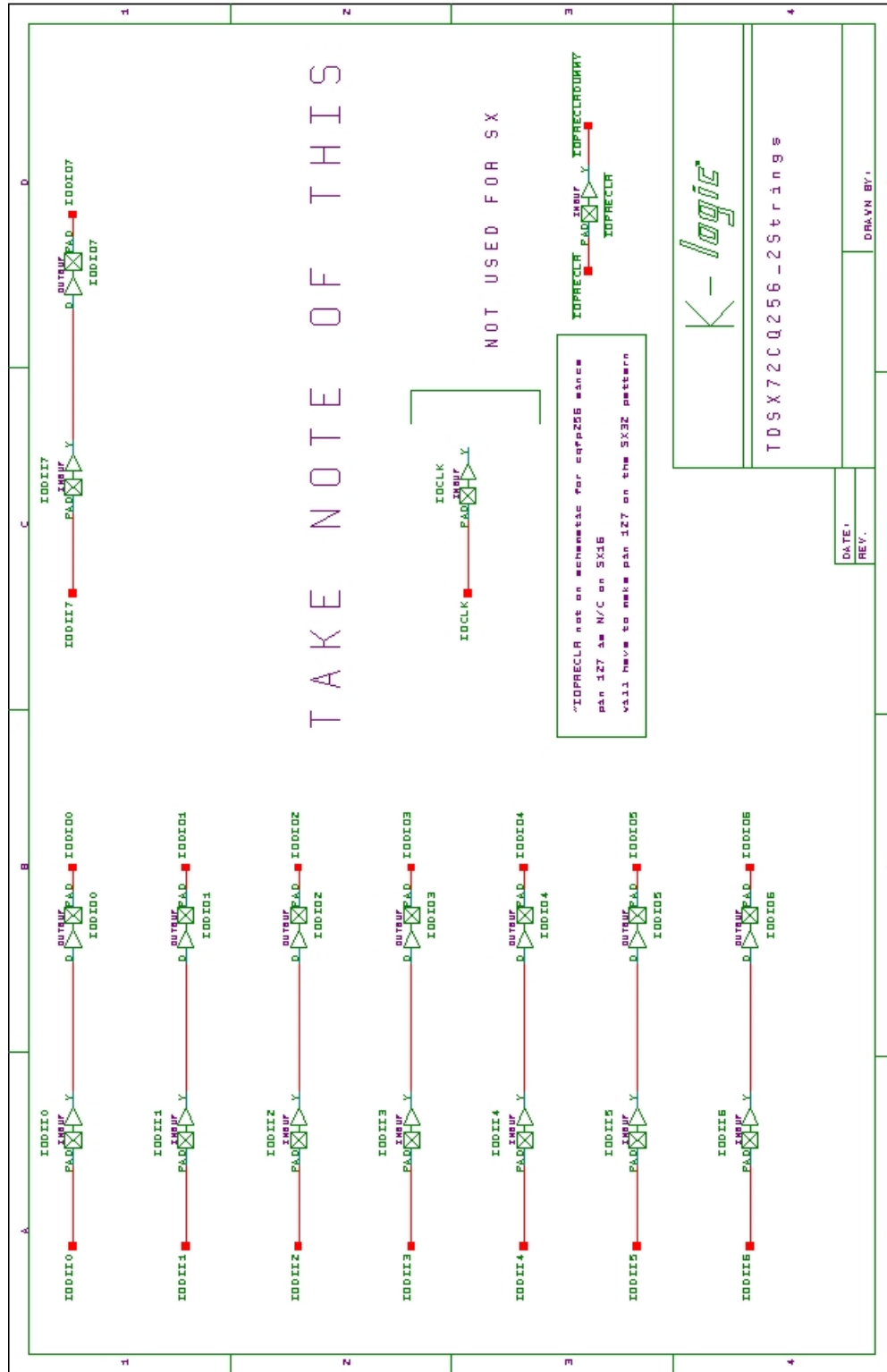


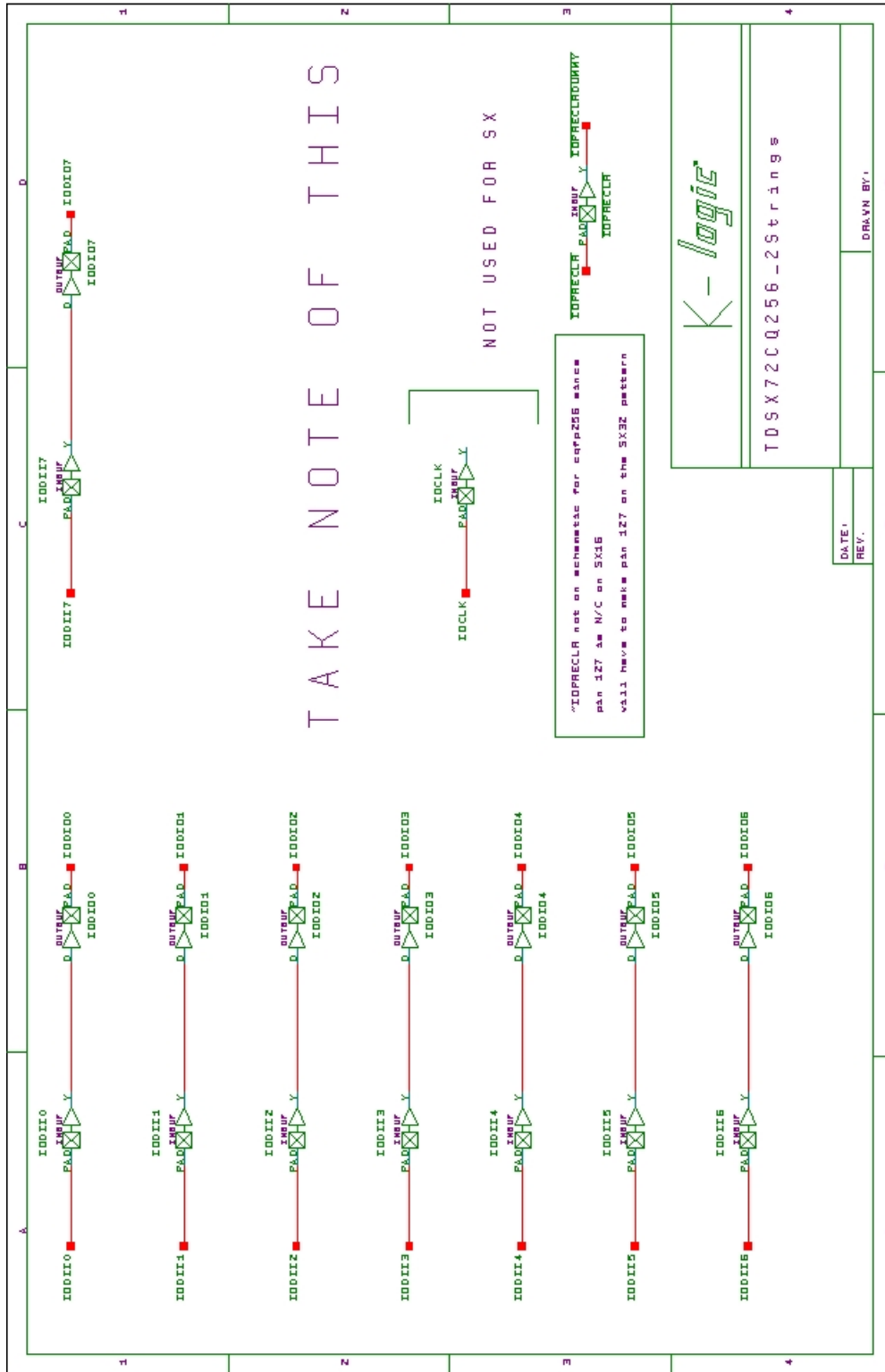


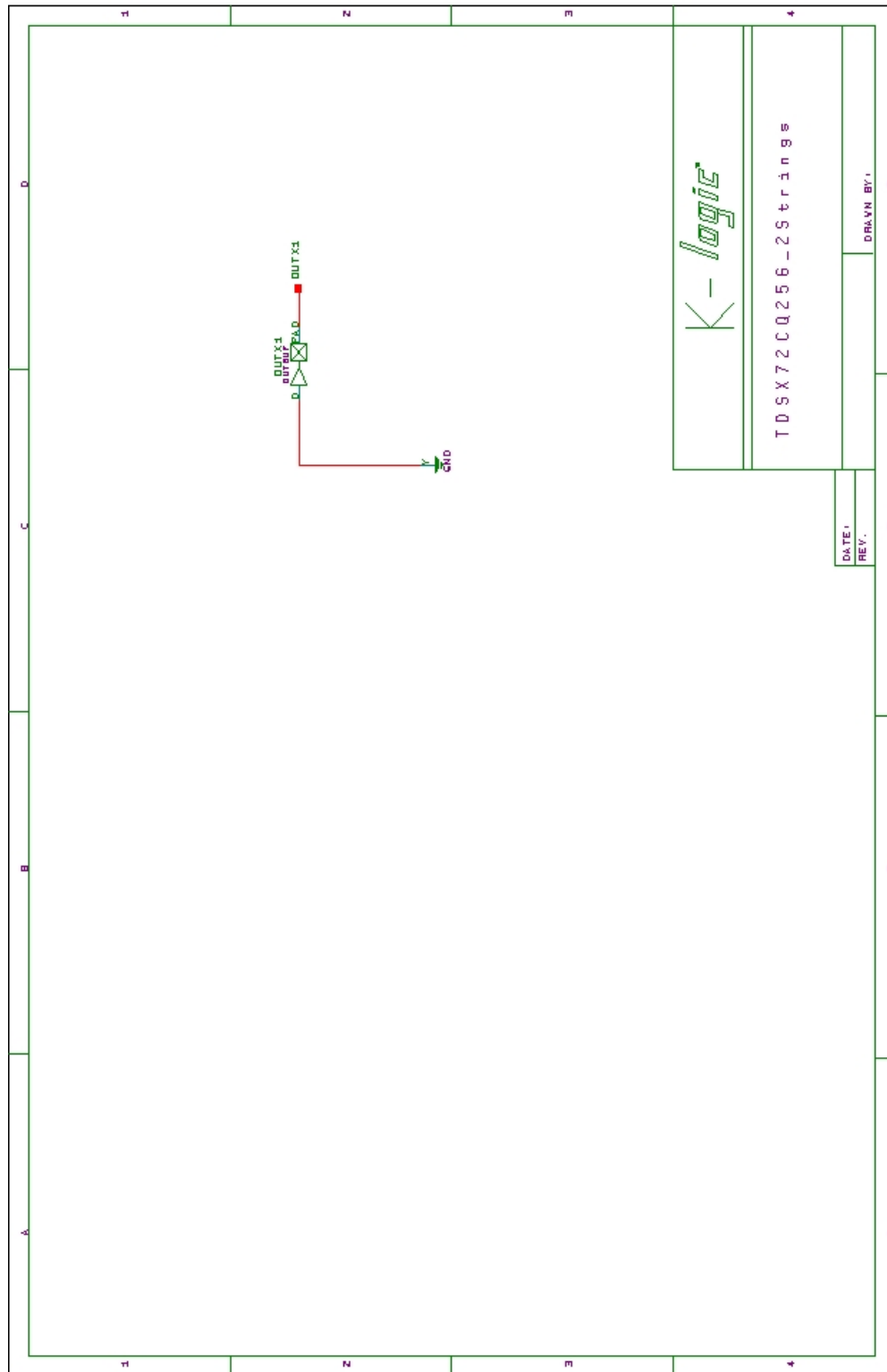
















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